Installation and Operation Manual X-TMF-5850E-MFC-eng Part Number: 541B102AAG September, 2009

Model 5850E Mass Flow Controller





Essential Instructions

Read this page before proceeding!

Brooks Instrument designs, manufactures and tests its products to meet many national and international standards. Because these instruments are sophisticated technical products, you must properly install, use and maintain them to ensure they continue to operate within their normal specifications. The following instructions must be adhered to and integrated into your safety program when installing, using and maintaining Brooks Products.

- Read all instructions prior to installing, operating and servicing the product. If this instruction manual is not the correct manual, please see back cover for local sales office contact information. Save this instruction manual for future reference.
- If you do not understand any of the instructions, contact your Brooks Instrument representative for clarification.
- Follow all warnings, cautions and instructions marked on and supplied with the product.
- Inform and educate your personnel in the proper installation, operation and maintenance of the product.
- Install your equipment as specified in the installation instructions of the appropriate instruction manual and per applicable local and national codes. Connect all products to the proper electrical and pressure sources.
- To ensure proper performance, use qualified personnel to install, operate, update, program and maintain the product.
- When replacement parts are required, ensure that qualified people use replacement parts specified by Brooks Instrument. Unauthorized parts and procedures can affect the product's performance and place the safe operation of your process at risk. Look-alike substitutions may result in fire, electrical hazards or improper operation.
- Ensure that all equipment doors are closed and protective covers are in place, except when maintenance is being performed by qualified persons, to prevent electrical shock and personal injury.

Pressure Equipment Directive (PED)

All pressure equipment with an internal pressure greater than 0.5 bar (g) and a size larger than 25mm or 1" (inch) falls under the Pressure Equipment Directive (PED). The Directive is applicable within the European Economic Area (EU plus Norway, Iceland and Liechtenstein). Pressure equipment can be traded freely within this area once the PED has been complied with.

- Section 1 of this manual contains important safety and operating instructions related to the PED directive.
- Meters described in this manual are in compliance with EN directive 97/23/EC module H Conformity Assessment.
- All Brooks Instrument Flowmeters fall under fluid group 1.
- Meters larger than 25mm or 1" (inch) are in compliance with category I, II, III of PED.
- Meters of 25mm or 1" (inch) or smaller are Sound Engineering Practice (SEP).

ESD (Electrostatic Discharge)

This instrument contains electronic components that are susceptible to damage by static electricity. Proper handling procedures must be observed during the removal, installation or other handling of circuit boards or devices.

Handling Procedure:

- 1. Power to unit must be removed.
- 2. Personnel must be grounded, via a wrist strap or other safe, suitable means before any printed circuit card or other internal device is installed, removed or adjusted.
- 3. Printed circuit cards must be transported in a conductive container. Boards must not be removed from protective enclosure until immediately before installation. Removed boards must immediately be placed in protective container for transport, storage or return to factory.

Comments

This instrument is not unique in its content of ESD (electrostatic discharge) sensitive components. Most modern electronic designs contain components that utilize metal oxide technology (NMOS, SMOS, etc.). Experience has proven that even small amounts of static electricity can damage or destroy these devices. Damaged components, even though they appear to function properly, exhibit early failure.

Dear Customer,

We appreciate this opportunity to service your flow measurement and control requirements with a Brooks Instrument device. Every day, flow customers all over the world turn to Brooks Instrument for solutions to their gas and liquid low-flow applications. Brooks provides an array of flow measurement and control products for various industries from biopharmaceuticals, oil and gas, fuel cell research and chemicals, to medical devices, analytical instrumentation, semiconductor manufacturing, and more.

The Brooks product you have just received is of the highest quality available, offering superior performance, reliability and value to the user. It is designed with the ever changing process conditions, accuracy requirements and hostile process environments in mind to provide you with a lifetime of dependable service.

We recommend that you read this manual in its entirety. Should you require any additional information concerning Brooks products and services, please contact your local Brooks Sales and Service Office listed on the back cover of this manual or visit www.BrooksInstrument.com

Yours sincerely, Brooks Instrument THIS PAGE WAS INTENTIONALLY LEFT BLANK

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1-1 Purpose

The Brooks[®] Model 5850E Flow Controller is a mass flow measurement device designed for accurately measuring and rapidly controlling flows of gases. This instruction manual is intended to provide the user with all the information necessary to install, operate and maintain the Brooks 5850E Mass Flow Controller. This manual is organized into five sections:

Section 1	Introduction
Section 2	Installation
Section 3	Operation
Section 4	Maintenance & Troubleshooting
Section 5	Replacement Parts
Back Cover	Warranty, Local Sales/Service Contact Information

It is recommended that this manual be read in its entirety before attempting to operate or repair the Model 5850E.

1-2 Description

The Brooks Model 5850E Mass Flow Controller is used widely in the Semiconductor Industry as well as many others, where manual, electronic or computer controlled gas handling occurs. The Model 5850E consists of three basic units: a flow sensor, a control valve and an integral electronic control system. This combination produces a stable gas flow, which eliminates the need to continuously monitor and readjust gas pressures. Standard features include:

- **Fast Response Control** permits rapid gas settling times with little or no over/undershoot. (Refer to Figure 1-1.)
- **Soft Start** provides a flow ramping function which slows down the introduction of the process gas for those processes which cannot tolerate rapid flow transition. (Refer to Section 2-6 and Figure 1-2.)
- Valve Override permits the user to fully open and close the control valve independent of the command setting. (Refer to Section 2-8.)
- Setpoint (Command) permits the user to program the mass flow controller with an external 0-5 Vdc command potentiometer. (Refer to Section 2-7.)
- Low Command Valve Inhibit (Auto Shut-off) prevents the valve from opening whenever the set-point is less than 2% of full scale.
- **Removable Cleanable Sensor** permits the user to clean or replace the sensor. (Refer to Section 4-4.)
- **Output Limiting** prevents possible damage to delicate data acquisition devices by limiting the output to +6.8 Vdc and -0.7 Vdc.

Section 1 Introduction

Brooks® Model 5850E

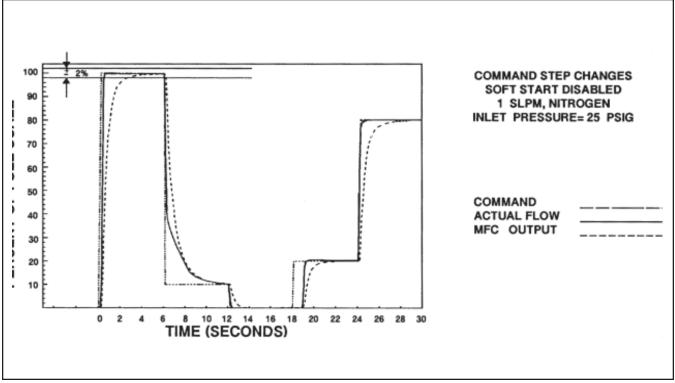


Figure 1-1 Command Steps, Soft Start Disabled

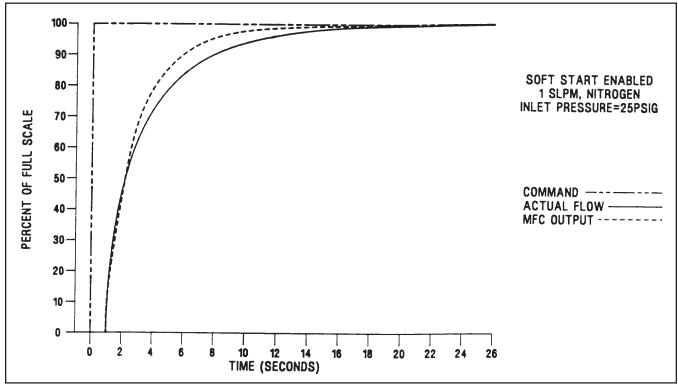


Figure 1-2 0 - 100% Command Step, Soft Start Enabled.

- Valve Off accessed via terminal J on the Card Edge or Pin 4 on the D-Connector version. This feature allows the user to close the control valve independently of the command signal by supplying a TTL level low signal to the proper terminal. This function is useful when performing repetitive flow operations or as a safety shutdown. (Refer to Section 2-11.)
- Valve Test Point/Purge accessed via terminal D on the Card Edge or Pin 7 on the D-Connector version. This feature allows the user to monitor the control valve voltage during operation. Shorting the valve test point pin to power supply common will cause the valve to open regardless of command input voltage. (Refer to Section 2-10.)
- Remote Transducer Input accessed via Terminal 5 on the Card Edge or Pin 15 on the D-connector version. This feature allows the use of the integral control electronics and valve to regulate flow in response to the signal from an external 0-5 Vdc signal. The mass flow signal from the Model 5850E is still available for process monitoring. (Refer to Section 2-9.)

AWARNING

Do not operate this instrument in excess of the specifications listed below. Failure to heed this warning can result in serious personal injury and/or damage to the equipment.

It is the user's responsibility to select and approve all materials of construction. Careful attention to metallurgy, engineered materials and elastomeric materials is critical to safe operation.

Standard Ranges:

3 sccm to 30 slpm* (Nitrogen equivalent)

*Standard temperature and pressure in accordance with SEMI (Semiconductor Equipment and Materials International) standard: 0°C and 101.3 kPa (760 Torr).

Accuracy:

 $\pm 1\%$ full scale including linearity at calibration conditions. $\pm 1.5\%$ full scale including linearity for flow ranges greater than 20 slpm.

Repeatability:

0.25% of rate

Response Time:

Less than 3 seconds response to within 2% of full scale final value with a 0 to 100% command step.

Power Requirements (NC Valve):

+15 Vdc ±5%, 35 mA -15 Vdc ±5%, 180 mA 3.5 watts power consumption

1-3 Specifications

Power Requirements (NO Valve):

+15 Vdc ±5%, 215 mA -15 Vdc ±5%, 180 mA 11.85 watts power consumption

Ambient Temperature Limits:

Operating: 40°F to 150°F (5°C to 65°C) Non-operating: -13°F to +212°F (-25°C to 100°C)

Working Pressure:

1500 psi (10.342 mPa) maximum

Differential Pressure: 5 to 50 psi (minimum pressure drop depends on gas and range). Refer to Orifice Sizing, Section 4-6.

Output Signal: 0-5 Vdc into 2000 ohms or greater. Maximum ripple 3 mV.

5 Volt Reference Output: 5 Volts ±0.2%. Maximum load 1 k ohms.

Temperature Sensitivity: Zero: less than $\pm 0.075\%$ F.S. per degree C. Span: less than $\pm 1.0\%$ F.S. shift over 10-50°C range

Power Supply Sensitivity: ±0.09% full scale per % power supply voltage variation

Mounting Attitude Sensitivity: ±0.5% maximum full scale deviation after re-zeroing

Command Input: 0-5 Vdc. Input resistance 200 k ohm

Leak Integrity: 1 x 10⁻⁹ Atm. cc/sec Helium

Control Range: 50 to 1

Mechanical Connection: Compatible with most popular mass flow controllers. Refer to Figure 2-1.

Electrical Connection: Card edge, 20 terminals, gold over low stress nickel plated copper. 15-pin D-Connector (DA-15P)

2-1 Receipt of Equipment

When the equipment is received, the outside packing case should be checked for damage incurred during shipment. If the packing case is damaged, the local carrier should immediately be notified regarding his liability. A report should be submitted to the Product Service Department, Brooks Instrument, 407 West Vine Street, Hatfield, Pennsylvania 19440.

Brooks Instrument

407 W. Vine Street P.O. Box 903 Hatfield, PA 19440 USA Toll Free (888) 554 FLOW (3569) Tel (215) 362 3700 Fax (215) 362 3745 E-mail: BrooksAm @BrooksInstrument.com www.BrooksInstrument.com

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Remove the envelope containing the packing list. Outside of your clean area, carefully remove the equipment from the packing case. Make sure spare parts are not discarded with the packing material. Inspect for damaged or missing parts.

2-2 Recommended Storage Practice

If intermediate or long-term storage is required for equipment, as supplied by Brooks Instrument, it is recommended that said equipment be stored in accordance with the following:

- a. Within the original shipping container.
- b. Store in a sheltered area, with the following conditions.
 - 1. Ambient temperature 21°C (70°F) nominal, 32°C (90°F) maximum and 7°C (45°F) minimum.
 - 2. Relative humidity 45% nominal, 60% maximum and 25% minimum. Upon removal from storage, a visual inspection should be conducted to verify the condition of the equipment is "as received". If the equipment has been in storage for an excess of ten (10) months or in conditions in excess of those recommended, all pressure boundary seals should be replaced and the device subjected to a pneumatic pressure test in accordance with applicable vessel codes.

Brooks[®] Model 5850E

2-3 Return Shipment

Prior to returning any Brooks equipment to the factory, contact the factory - for a Return Materials Authorization Number (RMA#). This can be obtained at Brooks Instrument, Product Service Department, 407 West Vine Street, Hatfield, PA 19440-0903, or call toll free 1-888-554-FLOW (3569).

Brooks Instrument

407 W. Vine Street P.O. Box 903 Hatfield, PA 19440 USA Toll Free (888) 554 FLOW (3569) Tel (215) 362 3700 Fax (215) 362 3745 E-mail: BrooksAm@BrooksInstrument.com www.BrooksInstrument.com

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Also, completion of Form RPR003-1, Brooks Instrument Decontamination Statement, as well as, a Material Safety Data Sheet (MSDS) for the fluid(s) used in the meter, is required before any Brooks Personnel can begin processing the equipment. Copies of the form can be obtained at one of the locations above.

2-4 Gas Connections

Standard inlet and outlet connections supplied on the Model 5850E are 1/4" compression fittings for flow rates up to 10 slpm, and 3/8" compression fittings for higher flow rates.

Optional VCO[™] and VCR[™] connections are available upon request. Prior to installation, make certain all piping is clean and free of obstructions. Install the piping in such a manner that permits easy removal if the instrument is to be removed for cleaning or test bench troubleshooting.

2-5 Installation (Refer to Figs. 2-1 through 2-4)

When installing the controller, care should be taken that no foreign materials enter the inlet or outlet of the instrument. Do not remove the protective end caps until time of installation.

Any sudden change in system pressure may cause mechanical damage to elastomer materials. Damage can occur when there is a rapid expansion of fluid that has permeated elastomer materials. The user must take the necessary precautions to avoid such conditions.

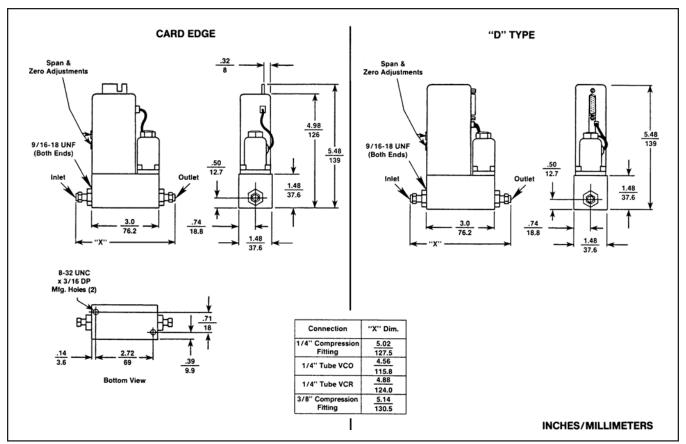


Figure 2-1 Model 5850E Dimensions

Any Brooks Instrument mass flow meter or flow controller with a 15 pin D-Connector PC Board bearing the "CE Mark" must use a 100% shielded cable and metal shell mating connectors. The shield is tied over 360 degrees to the shell at both ends. This is mandatory to be in compliance with the EMC Directive (89/336/EEC). Refer to Appendix A.

Recommended installation procedures:

- a. The Model 5850E should be located in a clean, dry atmosphere relatively free from shock and vibration.
- b. Leave sufficient room for access to the electrical components.
- c. Install in such a manner that permits easy removal if the instrument requires cleaning.

When used with a reactive (sometimes toxic) gas, contamination or corrosion may occur as a result of plumbing leaks or improper purging. Plumbing should be checked carefully for leaks and the controller purged with clean, dry N_2 before use.

d. The Model 5850E Mass Flow Controller can be installed in any position. However, mounting in orientations other than the original factory calibration (see data sheet) will result in a ±0.5% maximum full scale shift after re-zeroing.

Brooks® Model 5850E

			CARD EDGE	Ter	minal		CIRCUIT SIDE OF C BOAF		
Unit UFC-1000	Tylan FC-280	Tylan FC-260	Brooks 5850E	С	gnation ard dge	Brooks 5850E	Tylan FC-260	Tylan FC-280	Unit UFC-1000
Chassis Ground	Chassis Ground	Chassis Ground	Chassis Ground	1	A	Command Input	Command Input	Command Input	Command Input
Supply Common	0-5 Volt Signal Common	0-5 Volt Signal Common	0-5 Volt Signal Common	2	в	Command Common	Command Common	Signal & Command Common	Command Common
0-5 Volt Signal Output	0-5 Volt Signal Output	0-5 Volt Signal Output	0-5 Volt Signal Output	3	с	Supply Voltage Common	Supply Voltage Common	Return	Common
+ 15 Vdc Supply	+ 15 Vdc Supply	+ 15 Vdc Supply	+ 15 Vdc Supply	4	D	Valve Test Point/Purge	Valve Test Point	Not Used	Valve Test Point/Purge
Not Used	Not Used	Not Used	Remote Transducer Input***	5	Е	Not Used	Valve Not Used Point	Test	Not Used
Not Used	Zener Test	Zener Test	Not Used	6	F	- 15 Vdc Supply	- 15 Vdc Supply	- 15 Vdc Supply	- 15 Vdc Supply
Slot	Slot	Slot	Slot	7	Н*	Slot	Slot	Slot	Slot (G)
Not Used	Not Used	Not Used	Not Used	8	J*	Not Used	Not Used	Not Used	Not Used (H)
Not Used	Not Used	Not Used	Valve Override	9	K*	Not Used	Not Used Open/Close	Valve	Not Used (I)
Common	Not Used	Not Used	+ 5V Ref. *** or Valve Return or Not Used	10	L*	Valve Off	Not Used Off	Not Used	Valve Off (J)

* Unit designates Pins H, J, K, & L as G, H, I, & J

** Jumper Selectable

*** Factory Activated Option

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Brooks® Model 5850E

		Brown (Ref.) 211 413 615 817 10 9 12 11 Connector Connector Key (Supplied) 14 14 13 16 15 17 10 9 12 19 12 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 19 10 10 10 10 10 10 10 10 10 10	
PCB No.	Connector Pin No.	Black (Ref.)	Color Code
1	1	Chassis Ground	Brown
A	2	Command Input (Potentiometer Pin "S")	Red
2	3	0-5 V Signal Common	Orange
В	4	Command Common (Potentiometer Pin "CCW")	Yellow
3	5	0-5 V Signal Output	Green
С	6	Supply Voltage Common	Blue
4	7	+15 Vdc Supply	Violet
D	8	Valve Test Point/Purge	Gray
5	9	Not Used	White
Е	10	Not Used	Black
6	11	Not Used	Brown
F	12	-15 Vdc Input	Red
7	13	Slot	Orange
Н	14	Slot	Yellow
8	15	Not Used	Green
J	16	Not Used	Blue
9	17	Valve Override	Violet
ĩκ	18	Not Used	Gray
10	19	+5 V Reference Output (Potentiometer Pin "CW")** or Valve Return**	White
L	20	Valve Off	Black

Figure 2-3 Model 5850E Card Edge Connector Hookup Diagram

PIN NO.	FUNCTION	COLOR CODI
1	Command Common (Potentiometer Pin "CCW")	Black
2	0-5 Volt Signal Output	White
3	Not Used	Red
4	Valve Off	Green
5	+15 Vdc Supply	Orange
6	-15 Vdc Supply	Blue
7	Valve Test Point	Wht/Blk
8	Command Input (Potentiometer Pin "S")	Red/Blk
9	Supply Voltage Common	Grn/Blk
10	0-5 Volt Signal Common	Org/Blk
11	+5 Volt Reference Output (Potentiometer Pin "CW")	Blu/Blk
12	Valve Override	Blk/Wht
13	Not Used	Red/Wht
14	Chassis Ground	Grn/Wht
15	Remote Transducer Input*	Blu/Wht

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Notes:

- 1. Cable shield tied to chassis ground in meter connector. Make no connection on customer end.
- 2. All power leads must be connected to power supply.

Figure 2-4. D-Connector Pin Arrangement

e. When installing controllers with full scale flow rates of 10 slpm or greater, be aware that sharp, abrupt angles in the system piping directly upstream of the controller may cause a small shift in accuracy. If possible, have at least ten pipe diameters of straight tubing upstream of the Model 5850E Mass Flow Controller.

Note: The control valve in the Model 5850E provides precision control and is not designed for positive shut-off. If positive shut-off is required, it is recommended that a separate shut-off valve be installed in-line.

Since the Model 5850E control valve is not a positive shutoff, a separate solenoid valve may have been installed for that purpose. It should be noted that a small amount of gas may be trapped between the downstream side of the mass flow controller and the solenoid which will result in a surge upon actuation of the controller. This surge can be reduced in magnitude by locating, close together, the controller and solenoid valve or by moving the solenoid valve upstream of the controller.

2-6 In-Line Filter

It is recommended that an in-line filter be installed upstream from the controller to prevent the possibility of any foreign material entering the flow sensor or control valve. The filtering element should be replaced periodically or ultrasonically cleaned.

Table 2-1 Recommended Filter Size.

Maximum Flow Rate	Recommended Filter Size
100 sccm	1 micron
500 sccm	2 micron
1 to 5 slpm	7 micron
10 to 30 slpm	15 micron

Note: The above lists the maximum recommended porosity for each flow range. It is recommended that the minimum micron porosity that does not limit the full scale flowrate be used.

Electrical Interfacing

To insure proper operation, the Model 5850E must be connected per Figures 2-3 and 2-4, and configured according to Sections 2-6 to 2-13.

As a minimum the following connections must be made for new installations:

Chassis Ground 0-5 Volt Signal Common 0-5 Volt Signal Output +15 Vdc Supply -15 Vdc Supply Command Input Command Common Supply Voltage Common Valve Return (Refer to Section 2-12 for jumper configuration) For installations which replace Unit Instruments UFC-1000's, (Card Edge version) Pin 10 is frequently grounded. In these situations the 5 Volt reference output must be disabled. Refer to Section 2-12.

For installations which will be connected to Brooks secondary electronics, the Card Edge version must have the 5 Volt reference enabled on Pin 10 and the D-Connector version should be configured for external valve return. Refer to Section 2-12. If the Model 5850E was shipped as a system with Brooks secondary electronics then the electronics will already be configured properly.

Note: To obtain access to the jumpers for the following options the electronics cover can must be removed. Remove the can by removing the three screws and the valve connector. The can must be replaced before returning the unit to service.

2-7 Soft Start

Refer to Figures 3-3 and 3-4. To enable soft start, place the red jumper on the controller printed circuit board at J2 in the (ss) position.

To disable soft start, place the red jumper on the controller printed circuit board at J2 in the (n) position.

2-8 Remote Setpoint (Command) Input

If the mass flow controller is to be commanded by an external 0-5 Vdc signal, the command potentiometer is not used.

The command input hookup is as follows:

- a. Card Edge Connector
 Connect the external command voltage to Terminal A and external command return to Terminal B. Refer to Figures 2-2 and 2-3.
 b. D-Connector
- Connect the external command voltage to Terminal 8 and external command return to Terminal 1. Refer to Figure 2-4.

2-9 Valve Override

The valve override function allows full opening and closing of the valve independent of the command setting. The unique command reset feature prevents flow overshoot when the controller goes from valve override closed to normal control. The valve override for the mass flow controller is as follows:

- a. To open the valve, apply +15 Vdc to the valve override terminal.
- b. To close the valve, apply -15 Vdc to the valve override terminal.

- c. Isolating the valve override terminal returns the controller to normal operation.
 - 1. Card Edge
 - The valve override function can be accessed from Terminal 9. Refer to Figure 2-3.
 - Note: For normal operation, Terminal 9 must be left open (floating). 2. D-Connector
 - The valve override function is accessed from Terminal 12. Refer to Figure 2-4.

2-10 Remote Transducer Input

Refer to Figures 3-3 and 3-4. To allow the Model 5850E control circuitry and valve to be used with a 0-5 Vdc external transducer signal, a green jumper is moved to the lower two pins at J7. With this feature enabled, a 0-5 Vdc signal may be applied to the external transducer input terminal. The Model 5850E controller circuitry will modulate the valve position to increase or decrease the flow rate to maintain the transducer output at the desired set-point. The control circuitry is reverse acting, e.g., for an increase in transducer output, the flow will correspondingly be decreased.

2-11 Valve Test Point/Purge

Refer to Figures 2-2, 2-3 and 2-4. The valve voltage can be monitored on Pin D of the Card Edge version and Pin 7 of the D-Connector version. This voltage relative to circuit common is proportional to the valve voltage per the following equation:

Valve Voltage = $(1.53 \times TP3) + 20.7$

(Note: The valve voltage calculation is an approximate value.)

Shorting the valve test point pin to power supply common will cause the valve to open regardless of command input voltage.

2-12 Valve Off

Refer to Figures 2-2, 2-3 and 2-4. The control valve can be forced closed regardless of command input signal by applying a TTL level low (< .4 Vdc) to Terminal L of the Card Edge version or Pin 4 of the D-Connector version. A TTL level high or floating at this pin has no effect.

ACAUTION

Do not ground Terminal 10 when 5 Volt reference output is enabled. Irreparable damage to the printed circuit board may result.

2-13 Five-Volt Reference Output/Valve Drive Configuration

a. Card Edge

Refer to Figures 2-3 and 3-3. Terminal 10 can be jumper selected as 5 Volt reference output, external valve return or "not used." The 5 Volt reference output is required if a potentiometer is to be used to generate the command signal. To enable the 5 Volt reference output on Terminal 10, place the yellow jumper at J1 in the D-E position. To disable the 5 Volt reference output, place the yellow jumper at J1 in the E-F position.

Do not ground Terminal 10 when 5 Volt reference output is enabled. Irreparable damage to the printed circuit board may result.

To minimize the effect of resistance in the connection wiring, a separate "external valve return" can be accessed on Pin 10. To enable this feature, place the black jumper at J1 in the B-D position and connect Terminal 10 to power supply common. If the "external valve return" is not enabled, place the black jumper at J1 in the B-C position.

Note: If the "external valve return" feature is not enabled, the valve voltage is returned internally on the printed circuit board and the connection wiring resistance must be less than 0.2 ohms.

b. D-Connector

Refer to Figures 2-4 and 3-4. The 5 Volt reference is always available on Pin 11.

To minimize the effect of resistance in the connection wiring, a separate "external valve return" can be accessed on Pin 3. To enable this feature, place the black jumper at J1 in the B-D position and connect Pin 3 to power supply common. If the "external valve return" is not enabled, place the black jumper at J1 in the B-C position.

Note: If the "external valve return" feature is not enabled, the valve voltage is returned internally on the printed circuit board and the connection wiring resistance must be less than 0.2 ohms.

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3-1 Theory of Operation

The thermal mass flow sensing technique used in the Model 5850E works as follows:

A precision power supply provides a constant power heat input (P) at the heater which is located at the midpoint of the sensor tube. Refer to Figure 3-1. At zero, or no flow conditions, the heat reaching each temperature sensor is equal. The temperatures T1 and T2, therefore, are equal. When gas flows through the tube, the upstream sensor is cooled and the downstream sensor is heated which produces a temperature difference. The temperature difference T2-T1 is directly proportional to the gas mass flow. The equation is:

Where:

DT	=	Temperature difference T2 - T1 (°K)
Ср	=	Specific heat of the gas at constant pressure (kJ/kg-°K)
Р	=	Heater power (kJ/s)
m	=	Mass flow (kg/s)
А	=	Constant of proportionality (S ² -°K ² /kJ ²)

DT = A * P * Cp * m

A bridge circuit interprets the temperature difference and a differential amplifier generates a linear 0-5 Vdc signal directly proportional to the gas mass flow rate.

The flow restrictor shown in Figure 3-1 performs a ranging function similar to a shunt resistor in an electrical ammeter. The restrictor provides a pressure drop that is linear with flow rate. The sensor tube has the same linear pressure drop/flow relationship. The ratio of the restrictor flow to the sensor tube flow remains constant over the range of the meter. Different restrictors have different pressure drops and produce controllers with different full scale flow rates. The span adjustment, in the electronics, affects the fine adjustment of the controller's full scale flow.

In addition to the mass flow sensor, the Model 5850E Mass Flow Controller has an integral control valve and control circuit as shown in Figure 3-2. The control circuit senses any difference between the flow sensor signal and adjusts the current in the modulating solenoid valve to increase or decrease the flow. The Model 5850E has the following features incorporated in the integral control circuit:

Fast Response

Adjusted by the anticipate potentiometer, this circuit, when properly adjusted, allows the high frequency information contained in the sensor signal to be amplified. This provides a faster responding flow signal for remote indication and use by the control valve.

Soft Start

This is enabled by moving a jumper on the printed circuit board. This circuit provides a slow injection of the gas as a protection to the process, particularly those using a volatile or reactive gas. Full gas flow is achieved in approximately 15 seconds. Refer to Section 2-6.

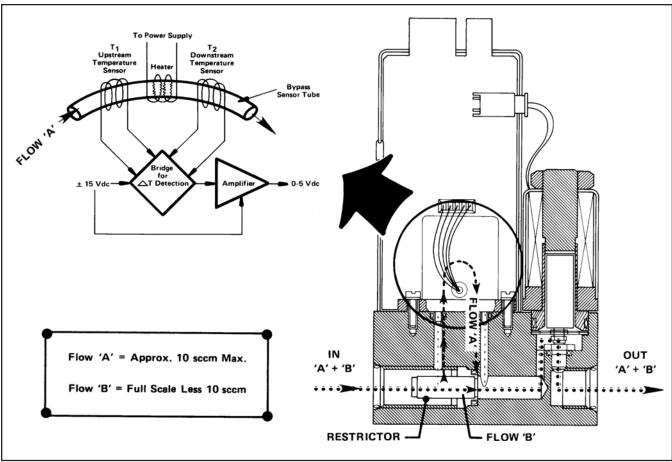


Figure 3-1 Flow Sensor Operational Diagram

Precision 5 Volt Reference

This allows direct connection of a command potentiometer to provide a 0-5 Volt command signal to the controller. A precision ten-turn 2K ohm potentiometer, with an integral turn counter, is recommended as this will permit repeatable adjustments of command to one part in 1,000. Refer to Section 2-13 for activation.

Valve Override

Allows, independent of the command setting, full opening and closing of the control valve. Refer to Section 2-8.

Valve Off

Accessed via Terminal L on the Card Edge or Pin 4 on the D-Connector version, this feature allows the user to close, independently of the command signal, the control valve by supplying a TTL level low signal to the proper terminal. This function is useful when performing repetitive flow operations or as a safety shutdown. Refer to Section 2-11.

Valve Test Point/Purge

Accessed via terminal D on the Card Edge or Pin 7 on the D-Connector version of the Model 5850E only. This feature allows the user to monitor

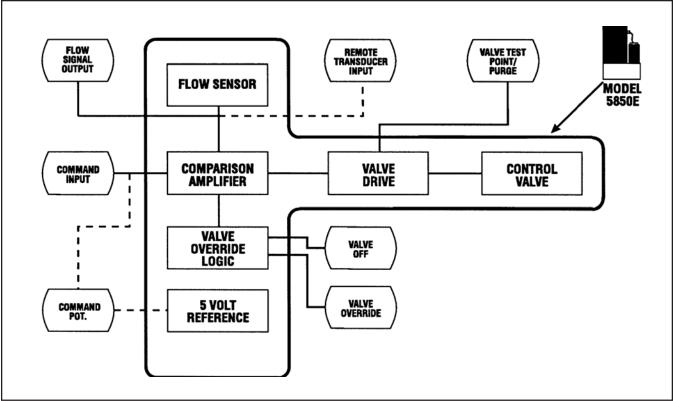


Figure 3-2 Flow Control System Block Diagram

the control valve voltage during operation, also grounding this terminal will cause the control valve to open independent of the command signal. Refer to Section 2-11.

Remote Transducer Input

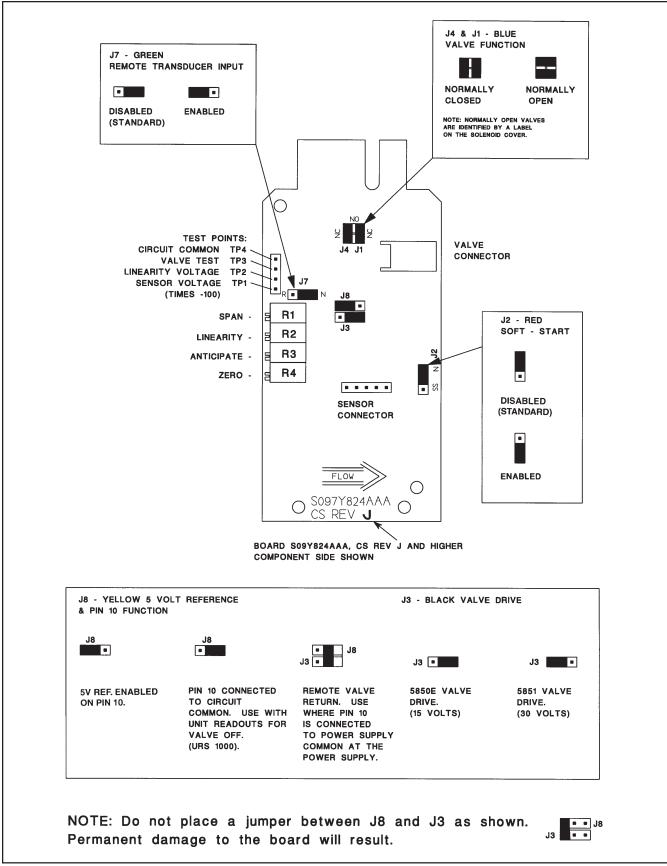
Accessed via terminal 5 on the Card Edge or Pin 15 on the D-Connector version. This feature allows the use of the integral control electronics and valve with the signal from an external 0-5 Vdc signal. The mass flow signal from the Model 5850E is still available for process monitoring. Refer to Section 2-9.

3-2 Operating Procedure

- a. Apply power to the controller and allow approximately 45 minutes for the instrument to warm-up and stabilize its temperature.
- b. Turn on the gas supply.
- c. Command 0% flow and observe the controllers output signal. If the output is not 0 mVdc (±10 mVdc), check for leaks and if none are found, refer to the re-zeroing procedure in Section 3-3.
- d. Set the command for the desired flow rate to assume normal operation.

3-3 Zero Adjustment

Each Model 5850E is factory adjusted to provide a zero $\pm 10 \text{ mVdc}$ signal at zero flow. The adjustment is made in our calibration laboratory which is temperature controlled to 21.1°C (70°F $\pm 2^{\circ}$ F). After initial installation and warm-up in the gas system, the zero flow indication may be other than the



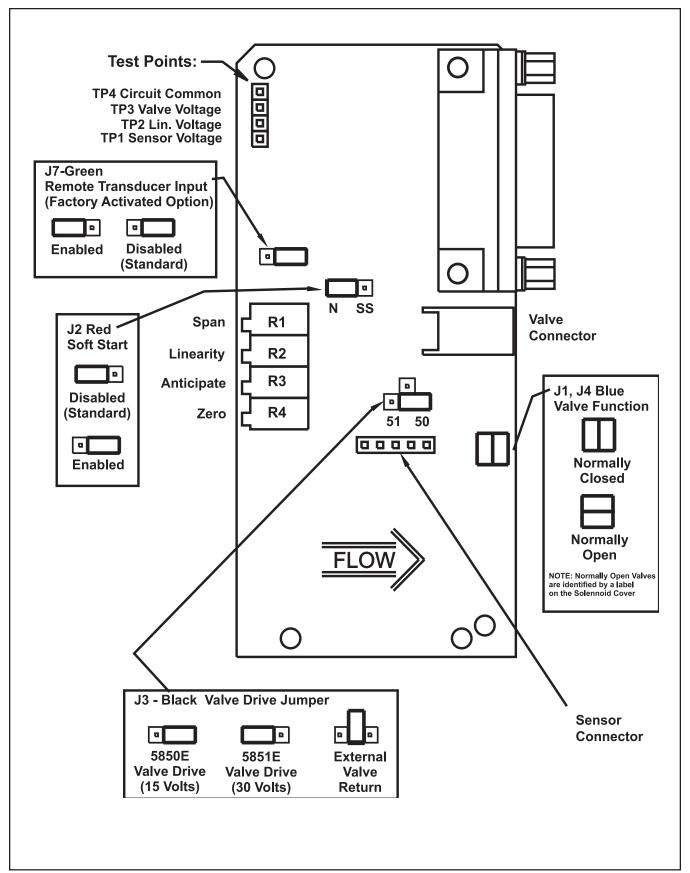


Figure 3-4 D-Connector PC Board Jumper Location and Function

Brooks[®] Model 5850E

CARD EDGE COMPONENT SIDE OF PC BOARD FLOW CARD EDGE CARD EDGE COMPONENT SIDE OF PC BOARD COMPONENT SIDE OF PC BOARD COMPONENT SIDE OF PC BOARD

Figure 3-5 Model 5850E Calibration Connections

factory setting. This is primarily caused by changes in temperature between the calibration laboratory and the final installation. The zero flow reading can also be affected, to a small degree, by changes in line pressure and mounting attitude.

To check zero, always mount the controller in its final configuration and allow a minimum of twenty minutes for the temperature of the controller and its environment to stabilize. Using a suitable voltmeter, check the controller output signal. If it differs from the factory setting, adjust it by removing the lower pot hole plug which is located closest to the controller body. Adjust the zero potentiometer (refer to Figure 3-6) until the desired output signal is obtained.

3-4 Calibration Procedure

Note 1: If the valve has been disassembled and any of the following parts have been replaced, the control valve adjusting procedure in Section 4-4c must be performed before the Model 5850E is calibrated.

orifice valve stem plunger lower guide spring valve seat

Note 2: Calibration of the Model 5850E mass flow controller requires the use of a digital voltmeter (DVM) and a precision flow standard calibrator such as the Brooks Instrument's Vol-U-Meter[®]. It is recommended that the calibration be performed only by trained and qualified service personnel.

Note 3: If the mass flow controller is to be used on a gas other than the calibration gas, apply the appropriate sensor conversion factor. Size the

orifice for actual operating conditions.

For the card edge model, do not ground Pin 10 with the 5 Volt reference enabled. Irreparable damage to the printed circuit board will result.

Note 4: If Brooks' secondary electronics are being used as a power supply during the calibration, the 5 Volt reference must be enabled on the Card Edge version for proper operation (see Section 2-13). Remember to deactivate the 5 Volt reference before installing the calibrated mass flow controller in the system where Terminal 10 is grounded.

- a. With the controller installed in an unpressurized gas line, apply power and allow approximately 45 minutes for warm-up. During the warm-up, adjustment and calibration check procedures do not allow the control valve to open when gas flow is not present. This situation is not a normal operating mode and will cause abnormal heat-up of the control valve. With this abnormally warm valve, the meter will be difficult to calibrate. This situation can be prevented by switching the valve override "closed" when there is no gas flow or by setting the command to less than one percent (1%). Also, avoid unnecessary periods with the valve override "open."
- b. Adjust the anticipate potentiometer with 20 clockwise full turns. Next, adjust the anticipate potentiometer with 10 counterclockwise turns to center the potentiometer. This will provide a rough adjustment of this circuit and make the flow more stable for calibration.
- c. Connect the DVM positive lead to the 0-5 Volt signal output (Terminal 3 Card Edge, Pin 2 D-Connector) and the negative lead to signal common (TP4). Adjust the zero potentiometer for an output of zero mV ±2 mV.
- Apply pressure to the system and insure that the zero signal repeats within 2 mV of the voltage set in Step "c" above. If the zero does not repeat, check for leakage.

Note: Controllers supplied with all metal or Teflon valve seats do not provide tight shut-off. A 0-8% leak-through is typical. For metal or Teflon seat controllers, close a downstream shut-off valve and observe the zero signal.

- e. Set the command potentiometer (connected to terminals A, B and 10 of the Card Edge connector and Terminals 1, 8 and 11 of the D-Connector) for 100% of flow (5.000V). Connect the DVM positive lead to TP2 (linearity voltage) and the negative lead to TP4 (signal common). Adjust the linearity potentiometer for an output of 0.0V (zero volts).
- f. Connect the DVM positive lead to TP1 (-100x sensor voltage) and the negative lead to TP4 (circuit common). The command potentiometer should still be set at 100% flow (5.000V). Measure the flow rate using suitable volumetric calibration equipment. To adjust the controller to the proper full scale flow, calculate a new TP1 voltage using the following equation:

New TP1	=	measured TP1 voltage	х	desired flow rate
Voltage		measured flow rate		

Brooks[®] Model 5850E

Adjust the span potentiometer until the voltage at TP1 is equal to the value calculated above. Recheck the flow rate after the flow is stable (at least two minutes). Repeat this check and adjustment procedure until the measured flow rate is within 1% of the desired flow rate. Note: The voltage at TP1 is -100 times the output voltage (+100 times for Current I/O Version) of the sensor. This voltage can range from -1.2 to -12 Volts, however, it is recommended that this voltage stay between -2.0 and -9.0 Volts for proper operation. If the recommended voltage range exceeds the desired range, accuracy and/or signal stability may not be achieved. If one of the limits is reached, check the restrictor and orifice sizing procedures. Refer to Sections 4-6 and 4-7 respectively.

- g. Set the command potentiometer for zero percent of flow. Connect the DVM positive lead to flow signal output (Terminal 3 Card Edge, Pin 2 D-Connector) and the negative lead to TP4. Readjust the zero potentiometer for an output of zero mV ±2 mV as necessary.
- h. Set the command potentiometer for 50% of flow (2.500V) and measure the flow rate. Calculate the error as a percentage of full scale.

Measured	-	Desired Flow
Flow Rate		Rate

Full Scale Error = 100%

Full Scale Flow Rate

Example:

What is the percent of full scale error when full scale is equal to 100 sccm?

Measured flow rate = 48.5 sccm, Desired flow rate = 50.0 sccm

Full Scale Error = 100 $\frac{(48.5 - 50)}{100} = -1.5\%$

i. Calculate the TP2 correction voltage: (error recorded in Step "h") x 0.450 Volts

Example:

Error = -1.5%

TP2 correction voltage = $-1.5 \times 0.450 = -0.675$ Volts

New TP2 voltage = zero volts + (-0.675) = -0.675 Volts

- j. Set the command potentiometer for 100% flow (5.000V). Connect the DVM positive lead to TP2 and the negative lead to TP4.
- k. Adjust the linearity potentiometer for an output equal to the new calculated TP2 voltage.
- I. Repeat Steps "f, g and h."
 - 1. If the error recorded in Step "h" is less than 0.5%, then the calibration procedure is complete.
 - 2. If the error is greater than 0.5%, set the command potentiometer for 100% (5.000V). Connect the DVM positive lead to TP2 (linearity voltage) and the negative lead to TP4 (circuit common). Calculate a new TP2 voltage as follows:

	error				measured
New TP2 voltage =	recorded in	х	0.450V	+	TP2
	Step "i"				voltage

Brooks[®] Model 5850E

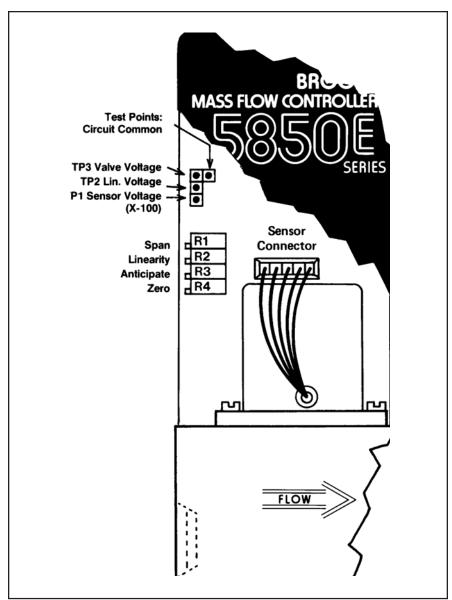


Figure 3-6 Adjustment Potentiometer Location

Example: Controller error = 0.7%Measured TP2 voltage = -0.567 Volts TP2 correction = $0.7 \times 0.450 = 0.315$ Volts New TP2 correction = 0.315 + (-0.567) = -0.252 Volts

Adjust the linearity potentiometer for an output equal to the new TP2 voltage and then repeat Steps "f," "g" and "h."

Note: The voltage at TP2 can range from -10 to +3 Volts. It is recommended, however, that this voltage stay between -2.5 and +2.5 Volts for proper operation. If the recommended voltage range is exceeded, the desired accuracy and/or signal stability may not be achieved. If one of the limits is reached, check the restrictor sizing (refer to Section 4-7).

3-5 Response

Fast Response Adjustment

Two methods of adjusting the step response of the Model 5850E mass flow controllers can be used. No. 1 describes a method that will get the step response close to optimum quickly and without any flow measuring equipment. This method should be used when the response time of the flow controller is not critical to overall system performance. No. 2 describes a method that will allow adjustment of the Model 5850E mass flow controller to optimum step response. Adjustment of the fast response circuit will not affect the accuracy of the flow controller as adjusted in Section 3-4.

1. Fast response adjustment (3 seconds response specification not guaranteed)

Note: This procedure requires an oscilloscope, chart recorder or a DVM with a sample speed of three samples per second or greater to monitor the rate of change of the output signal.

- a. Set the command potentiometer for 100% of flow (5.000V) and wait about 45 seconds for the flow output signal to stabilize.
- b. Step the command signal to 0% or activate valve override closed to stop the flow. Observe the flow signal output as it decays.
- c. The behavior of the flow signal during this transition between 100% and zero percent flow indicates the adjustment required of the anticipate potentiometer. Refer to Figure 3-7.
 - 1. If the flow signal decays to -.05 to -.5 Volt, then rises to zero Volts, the anticipate potentiometer is properly adjusted.
 - 2. If the flow signal decays rapidly and goes below -.5 Volt before rising to zero Volt, the anticipate potentiometer must be adjusted clockwise and Steps "a" and "b" repeated.
 - 3. If the flow signal decays slowly and does not go below -.5 Volt, the anticipate potentiometer must be adjusted counterclockwise and Steps "a" and "b" repeated.

Fast response adjustment (3 second response specification guaranteed)

Adjustment of the anticipate potentiometer to obtain a flow rate performance to be within 2% of flow rate commanded in less than three seconds (six seconds for Current I/O Version) after command change requires the use of a fast response flowmeter (500 millisecond response to be within 0.2% of final value or better) in series with the Model 5850E and

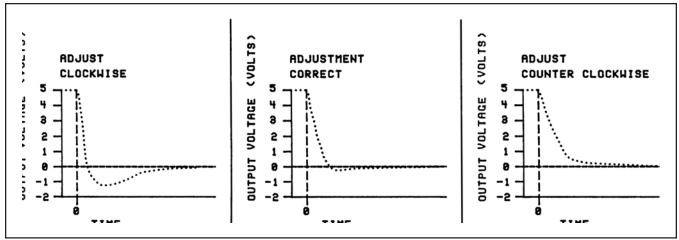


Figure 3-7 Fast Response Adjustment

a storage oscilloscope or recorder.

- a. Make a step change in command to the controller from zero to 100% of full scale flow and record the output signal of the fast response flowmeter.
- b. If this signal shows more than 4% overshoot, adjust the anticipate potentiometer one-half to one turn counterclockwise. If the signal does not show overshoot, but is not within 2% full scale of final value after three seconds (six seconds for Current I/O Version), adjust the anticipate potentiometer one-half to one turn clockwise. Set the command potentiometer for zero percent of flow.
- c. Repeat Steps "a" and "b" until the fast response flowmeter output signal meets the specified response requirements.

Note: With the above equipment, the anticipate potentiometer can be adjusted to give optimum response characteristics for any process.

THIS PAGE WAS INTENTIONALLY LEFT BLANK Installation and Operation Manual X-TMF-5850E-MFC-eng Part Number: 541B102AAG September, 2009

4-1 General

No routine maintenance is required on the Model 5850E. If an in-line filter is used, the filtering element should periodically be replaced or ultrasonically cleaned.



Products in this manual may contain metal or elastomeric seals, gaskets, O-rings or valve seats. It is the "user's" responsibility to select materials that are compatible with their process and process conditions. Using materials that are not compatible with the process or process conditions could result in the Meter or Controller leaking process fluid outside the pressure boundary of the device, resulting in personnel injury or death.

It is recommended that the user check the Meter or Controller on a regular schedule to ensure that it is leak free as both metal and elastomeric seals, gaskets, O-rings and valve seats may change with age, exposure to process fluid, temperature, and /or pressure.

4-2 Troubleshooting

If it becomes necessary to remove the instrument from the system, power to the device must be disconnected.

It is important that this controller only be serviced by properly trained and qualified personnel.

A. System Checks

The Model 5850E is generally used as a component in gas handling systems which can be quite complex. This can make the task of isolating a malfunction in the system a difficult one. An incorrectly diagnosed malfunction can cause many hours of unnecessary downtime. If possible, make the following system checks before removing a suspected defective mass flow controller for bench troubleshooting or return, especially if the system is new.

- Verify a low resistance common connection, correct power supply voltage and that signals are reaching and leaving the controller. The breakout board, P/N S273Z649AAA - Card Edge version or P/N S273Z668AAA - D-Connector version listed in Section 5, will make this job much easier.
- 2. Verify that the process gas connections have been correctly terminated and leak-checked.
- 3. If the mass flow controller appears to be functioning but cannot achieve set-point, verify that sufficient inlet pressure and pressure drop are available at the controller to provide the required flow.
- 4. Verify that all user selectable jumpers are in their desired positions (refer to Figures 3-3 and 3-4).

AWARNING

If it becomes necessary to remove the controller from the system after exposure to toxic, pyrophoric, flammable or corrosive gas, purge the controller thoroughly with a dry inert gas such as Nitrogen before disconnection the gas connections. Failure to correctly purge the controller could result in fire, explosion or death. Corrosion or contamination of the mass flow controller, upon exposure to air, may also occur.

B. Bench Troubleshooting

 Properly connect the mass flow controller to a ±15 Vdc power supply command voltage source and connect an output signal readout device (4-1/2 digit voltmeter recommended) to Terminals 2 and 3 or D-Connector Pins 2 and 10 (refer to Figures 2-2 and 2-3). Apply power, set the command voltage to zero and allow the controller to warm-up for 45 minutes. Do not connect to a gas source at this time. Observe the output signal and, if necessary, perform the zero adjustment procedure (Section 3-3). If the output signal will not zero properly, refer to the sensor troubleshooting section and check the sensor. If the sensor is electrically functional, the printed circuit board is defective and will require replacement.

2. Connect the controller to a source of the gas on which it was originally calibrated. Command 100% flow and adjust the inlet and outlet pressures to the calibration conditions. Verify that the output signal reaches and stabilizes at 5.000 Volts. Vary the command voltage over the 2 to 100% range and verify that the output signal follows the set-point.

Apply +15 Volts to the valve override input (refer to Figures 2-3 and 2-4 for terminal assignments) and verify that the output exceeds 5.000 Volts.

Apply -15 Volts to the valve override terminal and verify that the output signal falls below 0.100 Volts. If possible, connect a flow measurement device in series with the mass flow controller to observe the actual flow behavior and verify the accuracy of the mass flow controller. If the mass flow controller functions as described above, it is functioning properly and the problem is most likely elsewhere. Table 4-1 lists possible malfunctions which may be encountered during bench troubleshooting.

C. Sensor Troubleshooting

If it is believed the sensor coils are either open or shorted, troubleshoot using Table 4-2. If any of the steps do not produce expected results, the sensor assembly is defective and must be replaced. Refer to Section 4-4 for the disassembly and assembly procedures to use when replacing the sensor.

Note: Do not attempt to disassemble the sensor.

D. Cleaning

Should the Model 5850E Mass Flow Controller require cleaning due to deposition, use the following procedures:

- 1. Remove the unit from the system.
- 2. Refer to Section 4-4 to disassemble the controller.

Do not soak the sensor assembly in a cleaning solution. If solvent seeps into the sensor assembly, it will probably damage the sensor, or, at least, significantly alter its operating characteristics.

3. Use a hemostat or tweezers to push a 0.007" dia. piano wire through the flow sensor tube to remove any contamination. For best results push the wire into downstream opening of the sensor tube (end closest to the control valve). The sensor tube can be flushed with a non-residuous solvent (Freon TF[™] recommended). A hypodermic needle filled with solvent is a convenient means to accomplish this.

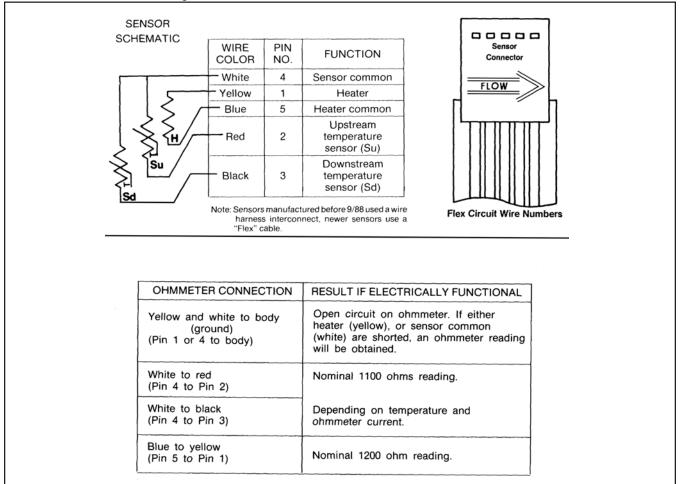
Table 4-1 Bench Troubleshooting

Trouble	Possible Cause	Check/Corrective Action
Actual flow overshoots setpoint by more than 5% full scale.	Anticipate potentiometer out of adjustment.	Adjust anticipate potentiometer. Refer to Section 3-5.
Output stays at 0 Volts regardless of command and there is no flow through the controller.	Clogged Sensor. Refer to Section 4-4.	Clean sensor. Refer to cleaning.
Output stays at 0 Volts regardless of command and there is no flow through the controller.	Clogged Control Valve	Check TP3 with the command valve at 100%. If the voltage is more negative than -11V for NC Valve or +11V for NO Valve, disassemble and repair the control valve. Refer to Section 4-4C and 2-10.
	Card Edge Version internal reference is being used as the command source and the yellow jumper is in the E-F position.	Refer to Section 2-12.
	-15 Volts applied to the valve override input	Check valve override input. Refer to Figures 2-3 & 2-4 for terminal assignments.
	Defective printed circuit board	Replace printed circuit board. Refer to Section 4-4.
	Valve voltage not returned, pin L at common.	Check jumper for external valve return. Refer to Section 2-12.
	"Valve-off" pin grounded.	Check "Valve-off" input. Refer to Figures 2-3 and 2-4 for terminal assignments.
Output signal stays at +6.8V regardless of command and there is flow	Valve stuck open or leaky.	Clean and/or adjust control valve. Refer to cleaning procedure and/or Section 4-4C.
through the controller.	+15V applied to the valve override input.	Check the valve override terminal. Refer to Figures 2-3 & 2-4 for terminal assignments.
	Detective printed circuit board.	Replace printed circuit board. Refer to Section 4-4.
	Command input floating.	Connect command signal. Refer to Figures 2-3 and 2-4 for terminal assignments.
	Pin D connected to common.	Remove Pin D from common.
Output signal follows setpoint at higher commands but will not go	Leaky control valve	Disassemble and repair valve. Refer to Section 4-4C.
to zero.	Excessive resistance in valve voltage	Reduce wiring resistance or re-configure controller for "External Valve Return:. Refer to Section 2-12.
Output signal follows setpoint at lower commands but does not reach	Insufficient inlet pressure or pressure drop.	Adjust pressure, inspect the filters and clear/replace as necessary.
full scale. Partially clogged valve.	Partially clogged sensor. Disassemble and repair control valve. Refer	Check calibration. Refer to Section 3-4.
Valve out of adjustment. Valve guide spring failure.	to Section 4-4. Adjust valve. Refer to Section 4-4. Controller oscillates (see below).	
Controller grossly out of calibration. Flow is higher than desired.	Partially clogged sensor.	Clean sensor, refer to the cleaning procedure.
Controller grossly out of calibration. Flow is lower than desired.	Partially clogged restrictor.	Replace restrictor. Refer to Section 4-4.
Controller oscillates.	Pressure drop or inlet pressure excessive.	Adjust pressures.
	Oversized orifice.	Check orifice size. Refer to Section 4-6.
	Valve out of adjustment.	Adjust valve. Refer to Section 4-4.
	Anticipate potentiometer out of adjustment.	Adjust anticipate potentiometer. Refer to Section 3-5.
	Faulty pressure regulator.	Check regulator output.
	Defective printed circuit board.	Replace printed circuit board. Refer to Section 4-4.

An alternate method for flushing out the sensor is to replace the restrictor element with a low flow plug restrictor. This plug forces all the flow through the sensor and may dislodge any obstructions. With the valve orifice removed, subject the flow controller to a high differential pressure. Pressurizing the outlet of the MFC higher than the inlet may help force the obstruction upstream and out of the sensor tube.

4. Inspect the orifice for clogging by holding it in front of a light source and looking for light through the bore. Clean by soaking in a suitable non-residuous solvent and directing a stream of compressed clean, dry Nitrogen through the bore.

Table 4-2 Sensor Troubleshooting



- Deposits of silicon dioxide may be removed by soaking the internal parts in solution of 5% hydrofluoric acid (5 parts hydrofluoric acid and 95 parts water (H₂O)) followed by Freon TF.
- Sintered type restrictor elements should be replaced as it is not possible to adequately remove deposits from them. Wire mesh and A.C.L.F.E. type restrictor elements can be cleaned in an ultrasonic bath. Refer to Section 4-7 for the correct restrictor to use.
- 7. Blow all parts dry with clean, dry Nitrogen and reassemble Refer to Section 4-4b, (assembly).
- 8. Purge the assembled controller with clean, dry Nitrogen.
- 9. Perform the calibration procedure in Section 3-4.
- 10.When the controller is reinstalled in the system, the connections should be leak-tested and the system purged with clean, dry Nitrogen for 30 minutes prior to start-up to prevent the formation of deposits.

4-3 Sensor Tube

The sensor tube is part of a calibrated flow divider that is designed to operate within a preset gas flow range. The sensor assembly may be removed or replaced by referring to Section 4-4, Disassembly and Assembly. If the sensor assembly is cleaned and reinstalled, a calibration check should be performed. Refer to Section 3-4.

4-4 Disassembly and Assembly

The Model 5850E Mass Flow Controller may be disassembled in the field by the user for cleaning, re-ranging or servicing. Disassemble and assemble the controller as follows: (for normally open valves N.O.) Figures 3-3 and 3-4 show the location and function of jumpers. The jumpers J4 and J1 (blue) must be in the position indicated for a normally open valve.

Figure (labeled 4-2) showing the location and function of valve adjustment spacers. Valve adjustment is not required for normal installation and operation of the mass flow controller. If adjustment is required, consult the factory for information.

Figure (labeled 5-1) showing an exploded view of the controller and specific parts to the normally open N.O. valve.

Note: The Model 5850E Mass Flow Controller should be disassembled and assembled in a clean environment to prevent particulate contamination.

A. Disassembly

The numbers in () refer to the spare parts exploded view in Figure 5-1.

AWARNING

Do not attempt to disassemble the mass flow controller until pressure has been removed and purging has been performed. Hazardous gas may be trapped in the valve assembly which could result in explosion, fire or serious injury.

- 1. Remove the jam nut (1) on top of the valve assembly.
- 2. Unplug the valve connector from the electronics cover and remove the coil assembly (2).
- Remove the hex socket screws (3) securing the valve retaining plate (4) attaching the valve stem assembly (6)(NC valve - Normally Closed) or (34) (NO Valve - Normally Open).

When performing the following procedure the valve stem must be removed without cocking it to prevent damage to the valve spring.

- Carefully remove the valve stem assembly (6)(NC Valve) or (34)(NO Valve).
- 5. Remove the plunger assembly (7,8,9,11)(NC Valve) or (35,31,32,8,9,11)(NO Valve).

- 6. Remove and note the position of the valve spring spacers (10), which may be located above and/or below the lower guide spring (8). Remove the preload spacer spring (33)(NO Valve).
- 7. Unscrew the orifice (12) from the flow controller body(14).
- 8. Carefully unscrew the valve seat (11) from the plunger assembly (7)(NC Valve) or the plunger assembly (31,32,35)(NO Valve).

Note the position and number of spacers (9) that are stacked on the threaded end of the valve seat.

9. Remove the three screws (20) attaching the electronics cover. Remove the electronics cover (23).

Be careful not to stress the sensor lead wire to sensor assembly junction when removing the sensor connector from the PC Board. If the sensor lead wires are stressed an open in the sensor wiring could result.

- 10.Unplug the sensor connector from the PC Board. Remove the two screws securing the bracket (24) and PC Board (15). Remove the bracket and PC Board.
- 11.Remove the two screws (18) and washers (19) securing the sensor assembly (16). Remove the sensor assembly.

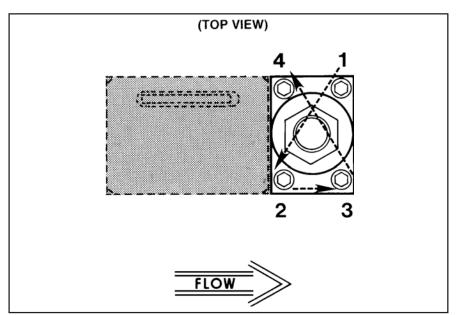


Figure 4-1 Torque Sequence for the Valve Retainer Plate

Note: Do not attempt to disassemble the sensor assembly.

Do not scratch the O-ring sealing service.

- 12.Remove the sensor assembly O-rings (17) from the flow controller body (14). Using the Brooks O-ring removal tool will help prevent scratching the sealing surface.
- 13. Remove the adapter fittings (27) from the flow controller body (14).
- 14.Remove the restrictor assembly (21) from the inlet side of the flow controller body (14) using the restrictor tool (part of service tool kit listed in Section 5, Table 5-2).

B. ASSEMBLY

Do not get Halocarbon lubricant on the restrictor element (21) or hands. This is a special inert lubricant which is not easily removed.

Note: It is recommended that all O-rings be replaced during controller assembly. All O-rings should be lightly lubricated with Halocarbon lubricant (part of O-ring kit, Section 5) prior to their installation.

- 1. Examine all parts for signs of wear or damage, replace as necessary.
- 2. Place the restrictor O-ring (22) on the restrictor assembly. Screw the restrictor assembly (21) into the inlet side of the flow controller body using the restrictor tool, tighten hand tight.

The following steps must be performed as written. Placing the O-rings on the sensor before it is installed will result in damage to the O-rings causing a leak.

- Press the lubricated sensor O-rings (17) into the flow controller body (14). Install the sensor assembly and secure with two screws (18) and washers (19) tightened to 15 in/lbs.
- 4. Install the orifice (12) and its O-ring (13), using a 3/8 nut driver. Insure that the orifice is fully seated but do not overtighten.
- 5. Insert the valve preload spacers (10)(NC Valve) or (33)(NO Valve), if used, into the valve cavity in the flow controller body (14). Use care to preserve the correct order.
- Place the spacers (9) and spring (8) on the valve seat (11) in the same order as noted in step 8 of the disassembly. Screw the valve seat (11) into the plunger assembly (7)(NC Valve) or (35,31,32)(NO Valve). Tighten the assembly until there is no looseness, but do not overtighten.
- Install the valve plunger assembly (7, 8, 9 and 11)(NC Valve) or (35,31,32,8,9,11)(NO Valve) on the preload spacers (10). Install air gap spacers (10), if used on top of the valve spring.
- 8. Install the valve stem assembly (6), secure with the valve retaining plate (4) and four hex socket screws (3). When installing the screws they should first make light contact with the plate, which should be checked to insure that it makes full contact around the stem assembly. Torque

the screws securing the valve retaining plate in diagonal pattern (Refer to Figure 4-1) to 17 in/lbs.

- Install the coil assembly (2) over the valve stem assembly (6)(NC Valve) or (34)(NO Valve) install extension spacer nut (3)(NO Valve) and secure with jam nut (1).
- 10.Install the printed circuit (PC) Board (15), secure with the bracket (24) and two screws. Plug the connector from the sensor assembly onto the PC Board. The flow arrow on the connector should be pointing toward the valve assembly.
- 11.Install the electronics cover (23) on the controller, secure with three screws (20). Plug the connector from the valve coil into the PC Board through the hole in the electronics cover.
- 12.Prior to installation leak and pressure test to any applicable pressure vessel codes.

C. Control Valve Adjustment

The Model 5850E control valve has been factory adjusted to insure proper operation. Readjustment is only required if any of the following parts have been replaced:

orifice (12) valve stem (6) plunger (7) lower guide spring (8) valve seat (11)

The valve is adjusted in Brooks' mass flow controllers by adding spacers (9 and 10) to the control valve assembly to vary the air gap and initial preload. Spacers are used to affect the proper adjustment because they provide a reliable and repeatable means for adjustment. Screw type adjustment mechanisms can change with pressure or vibration and introduce an additional dynamic seal that is a potential leak site and source for contamination. Refer to Fig. 4-2 for spacer locations.

In April 1989 a new valve stem and plunger combination was incorporated into the Model 5850E to improve the performance of the valve. These parts can be used as replacements in any Model 5850E, but the stem and plunger must be replaced at the same time.

The new style parts can be identified by a slightly curved surface on the bottom surface of the valve stem and two small groves in the plunger. The old style parts have a flat surface on the bottom of the stem and one or no groove in the plunger. Please refer to Figure 4-2 for an illustration of the difference.

Valves incorporating the old style parts may or may not have a small diameter air gap spacer, and always use two lower guide springs. The new style parts always include a .010" thick small diameter air gap spacer. For devices with an orifice diameter of 0.020" and less the 0.025" thick lower guide spring is used. For devices with an orifice diameter of 0.032" and larger the 0.020" lower guide spring is used. Although the newer valve parts are assembled slightly differently than the old parts, the adjustment procedure that follows is the same for both types of parts.

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The preload determines the initial force that is required to raise the valve seat off the orifice and start gas flow. If the preload is insufficient, the valve will not fully close and gas will leak through. If the preload is excessive, the magnetic force generated between the plunger and stem will not be sufficient to raise the plunger and the valve will not open.

The airgap is the space between the top of the plunger and stem. The airgap determines the force between the plunger and stem at a given voltage and the total travel of the valve. If the airgap is too small, the plunger travel may not be sufficient to fully open the valve. Also, the magnetic force may be too high for a given valve coil voltage. If the airgap is too large, the magnetic force will not be sufficient to raise the plunger and the valve will not open.

Note: Prior to starting the valve adjustment procedure, check to insure that the orifice is properly seated and that the valve parts are not bent or damaged.

- 1. Adjustment Procedure (Refer to Section 5, Spare Parts, for the spacer kit)
 - a. Remove the electronics cover (23) from the controller. Insure that the connector from the coil assembly (2) is properly reconnected to the PC Board after the electronics cover is removed.
 - b. Perform the electrical and gas connections to the controller following the instructions in Section 2 of this manual. Use a clean, dry inert gas, such as Nitrogen, for this procedure. Do not apply gas pressure to the controller at this time.
 - c. Disassemble the control valve following the procedure given in Section 4-4a, above. Note the number, locations and thicknesses of all the spacers (9 and 10).
 - d. Decrease the preload of the valve by 0.005 inches either by removing a 0.005" small preload spacer or by adding a 0.005" large preload spacer. Refer to Fig.4-2.
 - e. Reassemble the valve following the assembly procedure in Section 4-4a.
 - f. Command 0% flow, apply normal operating pressure and check for valve leak-through by observing the output signal.
 - g. If the valve leaks-through, increase the preload by 0.005" and go to Step h. If the valve does not leak-through, repeat Steps d, e, f and g.
 - h. Apply the normal operating gas pressure and command 100% flow (5.000 Volts on Terminal A, Pin 2).

Note: Due to possible heat capacity and density differences between the test gas and actual process gas for which the mass flow controller was sized, it may be necessary to increase the inlet pressure to obtain proper control at 100% flow.

- Measure the valve voltage by connecting a voltmeter between Test Point 3 (TP3) and Test Point 4 (TP4). Refer to Figure 4-3.
 Valve Voltage = (1.53 x TP3) + 20.7
- j1. If the flow controller output signal is 100% (5.0V) and the valve voltage is less than 11.5 Volts, the valve adjustment is complete.

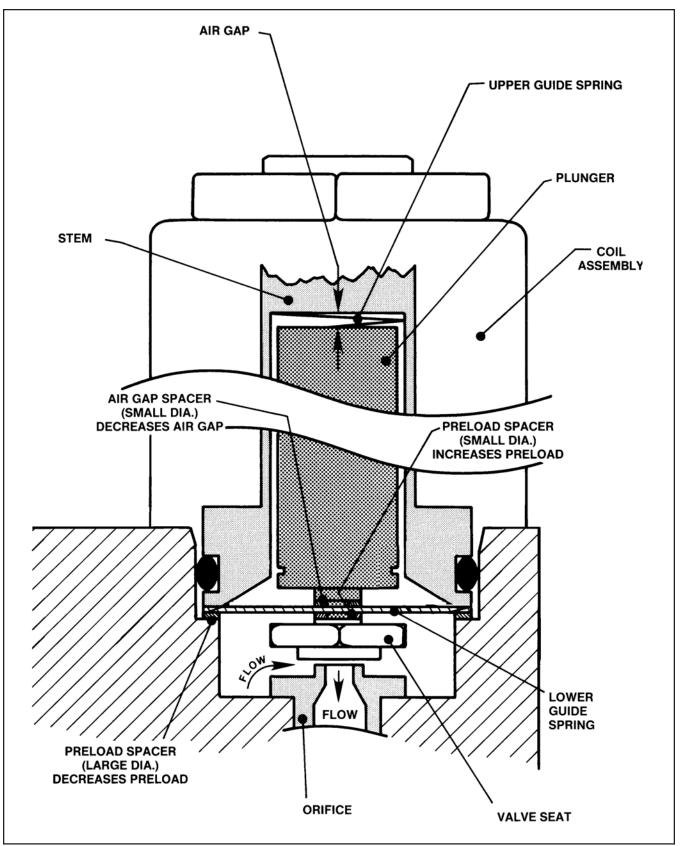


Figure 4-2a Valve Adjusting Spacer Locations (Normally Closed valve N.C.)

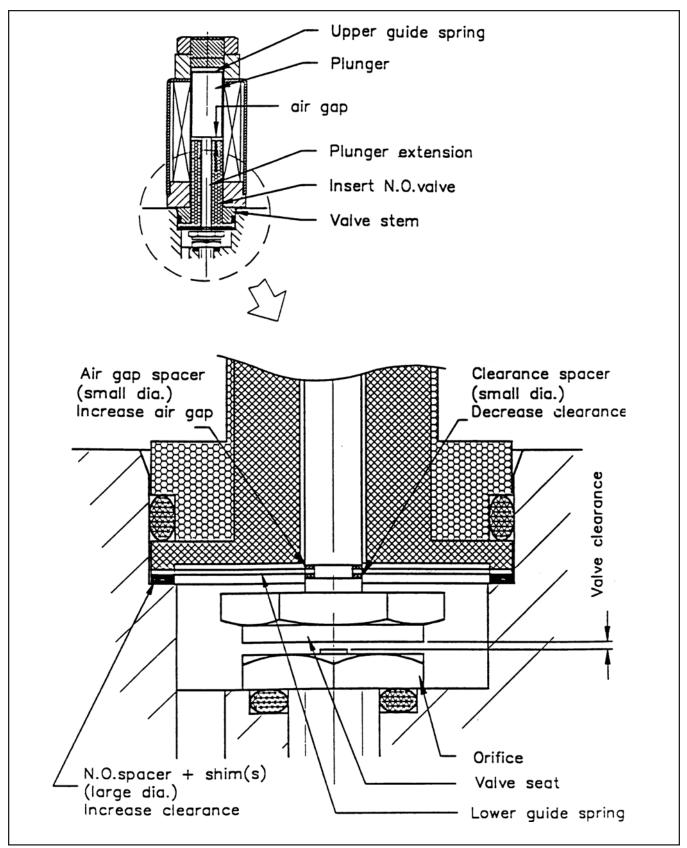


Figure 4-2b Valve Adjusting Spacer Locations (Normally Open valve N.O.)

- j2. If the flow controller output signal is 100% (5.0V) and the valve voltage is greater than 11.5 Volts, decrease the air gap with a small 0.005 inch air gap spacer. Refer to Figure 4-2. Repeat Steps h and i.
- j3. If the flow controller output signal is less than 100% (5.0V) and the valve voltage is greater than 11.5V. This condition indicates that the inlet pressure is too low and or the orifice size is too small. First check Section 4-6 to insure that the orifice size is correct.
- k. Proceed to Section 3 and perform 3-4 Calibration Procedure, if required.

4-5 Gas Conversion Factors

If a mass flow controller is operated on a gas other than the gas it was calibrated with, a scale shift will occur in the relation between the output signal and the mass flow rate. This is due to the difference in heat capacities between the two gases. This scale shift can be approximated by using the ratio of the molar specific heat of the two gases or by sensor conversion factor. A list of sensor conversion factors is given in Table 4-3. To change to a new gas, multiply the output reading by the ratio of the gas factor for the desired gas by the gas factor for the calibration gas.

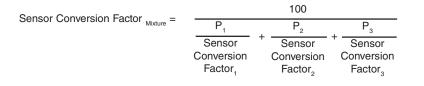
Actual Gas Flow Rate = Output Reading x $\frac{Factor of the New Gas}{Factor of the Calibration Gas}$

Example:

The controller is calibrated for nitrogen. The desired gas is carbon dioxide The output reading is 75 sccm when carbon dioxide is flowing

Then 75 x 0.773 = 57.98 sccm

In order to calculate the conversion factor for a gas mixture, the following formula should be used:



Where,

 P_1 = percentage (%) of gas 1 (by volume)

 P_2 = percentage (%) of gas 2 (by volume)

 $P_n = percentage (\%) of gas n (by volume)$

Example: The desired gas is 20% Helium (He) and 80% Chlorine (Cl) by volume. The desired full scale flow rate of the mixture is 20 slpm. Sensor conversion factor for the mixture is:

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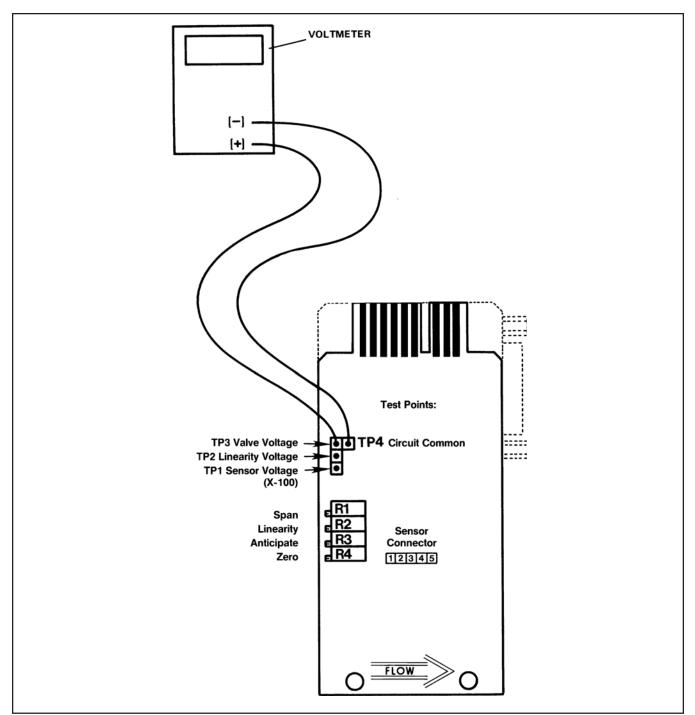


Figure 4-3 Voltmeter Connections for Valve Adjustment

GAS NAME	FORMULA	SENSOR FACTOR	ORIFICE FACTOR	DENSITY (kg/m ³
Acetylene	C ₂ H ₂	0.615	0.970	1.173
Air	Mixture	0.998	1.018	1.293
Allene	C ₃ H ₄	0.478	1.199	1.787
Ammonia	NH ₃	0.786	0.781	0.771
Argon	Ar	1.395	1.195	1.784
Arsine	AsH ₃	0.754	1.661	3.478
Boron Trichloride	BCL ₃	0.443	2.044	5.227
Boron Trifluoride	BF ₃	0.579	1.569	3.025
Bromine Pentafluoride		0.287	2.502	7.806
	BrF ₅			
Bromine Trifluoride	BrF ₃	0.439	2.214	6.108
Bromotrifluoroethylene	C ₂ BrF ₃	0.326	2.397	7.165
Bromotrifluoromethane f-13B1	CBrF。	0.412	2.303	6.615
1.3-Butadiene	C4H6	0.354	1.413	2.491
Butane	$C_4 H_{10}$	0.257	1.467	2.593
1-Butene	C_4H_8	0.294	1.435	2.503
CIS-2-Butene	C ₄ H ₈	0.320	1.435	2.503
Trans-2-Butene	C,H,	0.291	1.435	2.503
Carbon Dioxide	co,	0.740	1.255	1.977
Carbon Disulfide	CS ₂	0.638	1.650	3.393
Carbon Monoxide	СО	0.995	1.000	1.250
Carbon Tetrachloride		0.344	2.345	6.860
Carbon Tetrafluoride f-14	CF ₄	0.440	1.770	3.926
Carbonyl Fluoride	COF ₂	0.567	1.555	2.045
Carbonyl Sulfide	COS	0.680	1.463	2.180
•				
Chlorine	CL ₂	0.876	1.598	3.214
Chlorine Dioxide	CLO ₂	0.693	1.554	3.011
Chlorine Trifluoride	CLF ₃	0.433	1.812	4.125
2-Chlorobutane	C,H,ČI	0.234	1.818	4.134
Chlorodifluoromethane f-22	CHCLF,	0.505	1.770	3.906
Chloroform (Trichloromethane)	CHCL ₃	0.442	2.066	5.340
Chloropentafluoroethane f-115	C ₂ CLF ₅	0.243	2.397	7.165
Chlorotrifluoroethylene	C ₂ CLF ₃	0.337	2.044	5.208
Chlorotrifluoromethane f-13		0.430	1.985	4.912
Cyanogen		0.498	1.366	2.322
	(CN) ₂			
Cyanogen Chloride	CLCN	0.618	1.480	2.730
Cyclobutane	C ₄ H ₈	0.387	1.413	2.491
Cyclopropane	C ₃ H ₆	0.505	1.224	1.877
Deuterium	D ₂	0.995	0.379	0.177
Diborane	B ₂ H ₆	0.448	1.000	1.235
Diboromodifluoromethane f-12B2	CBr ₂ F ₂	0.363	2.652	8.768
1,2-Dibromotetrafluoroethane f-114B2	C ₂ Br ₂ F ₄	0.215	2.905	10.53
Dichlorodifluoromethane f-12	CCL ₂ F ₂	0.390	2.099	5.492
Dichlorofluoromethane f-21	CHCL,F	0.456	1.985	4.912
Dichlorosilane	SiH,CL,	0.442	1.897	4.506
1,2-Dichloroethane	C ₂ H ₄ Cl ₂	0.382	1.879	4.419
1,2-Dichlorotetrafluoroethane f-114	C ₂ CL ₂ F ₄	0.231	2.449	7.479
2,2 Dichloro	$C_2HC_{12}F_3$	0.259	2.336	6.829
1,1-Difluoro-1-Chloroethane	C ₂ H ₃ CLF ₂	0.341	1.957	4.776
1,1-Difluoroethane	CH ₃ CHF,	0.415	1.536	2.940
1,1-Difluoroethylene	CH ₂ CF ₂	0.458	1.512	2.860
Diethylsilane	C ₄ H ₁₂ Si	0.183	1.775	3.940
Difluoromethane f-32	CF ₂ H ₂	0.627	1.360	2.411
Dimethylamine	(CH ₃) ₂ NH	0.370	1.269	2.013
Dimethylether	(CH ₃) ₂ O	0.392	1.281	2.055
2,2-Dimethylpropane	C(CH ₃) ₄	0.247	1.613	3.244
Disilane	Si ₂ H ₆	0.332	1.493	2.779
Ethane	C ₂ H ₆	0.490	1.038	1.357
Ethanol	C ₂ H ₆ O	0.394	1.282	2.057
Ethylacetylene	C ₄ H ₆	0.365	1.384	2.388
Ethyl Chloride	C,H,CL	0.408	1.516	2.879
Ethylene	C ₂ H ₄	0.619	1.000	1.261
5				
Ethylene Oxide	C,H ₄ O	0.589	1.254	1.965
Fluorine	F ₂	0.924	1.163	1.695
Fluoroform f-23	CHF ₃	0.529	1.584	3.127
Germane	GeH₄	0.649	1.653	3.418
Germanium Tetrachloride	GeCl	0.268	2.766	9.574
Halothane (R-123B1)	C ₂ HBrClF ₃	0.257	2.654	8.814
. ,	2 0			
Helium	He	1.386	0.378	0.178
Hexafluoroacetone	F ₃ CCOCF ₃	0.219	2.434	7.414
losandorodootorio	CE	0.632	2.577	8.309
	U.L.			
Hexaflorobenzine	C ₆ F ₆	0.255	2 210	6 1 20
Hexaflorobenzine Hexafluoroethane f-116	C_2F_6	0.255	2.219	6.139
Hexaflorobenzine Hexafluoroethane f-116 Hexafuoropropylene (HFP)	C ₂ F ₆ C ₃ F ₆	0.249	2.312	6.663
Hexaflorobenzine Hexafluoroethane f-116 Hexafuoropropylene (HFP) Hexamethyldisilane (HMDS)	C_2F_6			

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Table 4-3 Conversion Factors (Nitrogen Base) Continued

GAS NAME	FORMULA	SENSOR FACTOR	ORIFICE FACTOR	DENSITY (kg/m³)
Hydrogen	H ₂	1.008	0.269	0.090
Hydrogen Bromide	HBr	0.987	1.695	3.645
Hydrogen Chloride	HCL	0.983	1.141	1.639
Hydrogen Cyanide	HCN	0.744	0.973	1.179
Hydrogen Fluoride	HF	0.998	0.845	0.893
Hydrogen lodide	н	0.953	2.144	5.789
Hydrogen Selenide	H ₂ Se	0.837	1.695	3.613
Hydrogen Sulfide	H _s S	0.850	1.108	1.539
lodine Pentafluoride	IF ₅	0.283	2.819	9.907
Isobutane	C4H10	0.260	1.440	2.593
Isobutene		0.289	1.435	2.503
	C ₄ H ₈			
Isopentane	C ₅ H ₁₂	0.211	1.605	3.222
Krypton	Kr	1.382	1.729	3.708
Methane	CH4	0.763	0.763	0.717
Methylacetylene	C ₃ H ₄	0.473	1.196	1.782
Methyl Bromide	CH _a Br	0.646	1.834	4.236
•				
3-Methyl-1-butene	C ₅ H ₁₀	0.252	1.584	3.127
Methyl Chloride	CH ₃ CL	0.687	1.347	2.308
Methyl Fluoride	CH	0.761	1.102	1.518
Methyl Mercaptan	CH _A S	0.588	1.313	2.146
Methyl Silane	CH ₆ Si	0.393	1.283	2.061
Methyl Trichlorosilane (MTS)	CH ₃ Cl ₃ Si	0.267	2.310	6.675
Methyl Vinyl Ether	C ₃ H ₆ O	0.377	1.435	2.567
Monoethanolamine	C ₂ H ₇ NO	0.305	1.477	2.728
Monoethylamine	C ₂ HH ₅ NH ₂	0.359	1.269	2.013
Monomethylamine	CH ₃ NH ₂	0.565	1.067	1.420
Neon	Ne	1.398	0.847	0.902
Nickel Carbonyl	Ni(CO) ₄	0.212	2.371	7.008
-				
Nitric Oxide	NO	0.995	1.030	1.339
Nitrogen	N ₂	1.000	1.000	1.251
Nitrogen Dioxide	NO ₂	0.758	1.713	2.052
Nitrogen Trifluoride	NF ₃	0.501	1.598	3.168
-				
Nitrogen Trioxide	N ₂ O ₃	0.443	1.649	3.389
Nitrosyl Chloride	NOCL	0.644	1.529	2.913
Nitrous Oxide	N ₂ O	0.752	1.259	1.964
Octofluorocyclobutane	C ₄ F ₈	0.169	2.672	8.933
Oxygen	O ₂	0.988	1.067	1.429
Oxygen Difluoride	OF ₂	0.672	1.388	2.402
Ozone	O ₃	0.738	1.310	2.138
Pentafluorethane f-125	C ₂ HF ₅	0.287	2.070	5.360
Pentane (n-Pentane)	C ₅ H ₁₂	0.212	1.605	3.222
Perchloryl Fluoride	CLO ₃ F	0.448	1.905	4.571
-				
Perfluorobutane	C ₄ F ₁₀	0.738	2.918	10.61
Perfluoro-2-Butene	C_4F_8	0.268	2.672	8.933
Perfluoromethyl-vinylether	PMVE	0.296	2.029	5.131
Perfluoropropane	C ₃ F ₈	0.179	2.591	8.396
Pentane (n-Pentane)	C ₅ H ₁₂	0.212	1.605	3.222
Phosgene	COCL ₂	0.504	1.881	4.418
Phosphine	PH ₃	0.783	1.100	1.517
Phosphorous Pentafluoride	PF ₅	0.346	2.109	5.620
Phosphorous Trifluoride	PF ₃	0.495	1.770	3.906
•				
Propane (same as CH ₃ CH ₂ CH ₃)	C ₃ H ₈	0.343	1.274	2.008
Propylene (Propene)	C ₃ H ₆	0.401	1.234	1.875
Rhenium Hexafluoride	ReF	0.230	3.279	13.41
Silane	SiH	0.625	1.070	1.440
				7.579
Silicon Tetrachloride			2 165	1.319
Silicon Tetrachloride	SiCL ₄	0.310	2.465	1 0 1 0
Silicon Tetrafluoride	SiF ₄	0.395	1.931	4.648
	SiF ₄ SO ₂			4.648 2.858
Silicon Tetrafluoride	SiF ₄ SO ₂	0.395	1.931	
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride	SiF ₄ SO ₂ SF ₆	0.395 0.728 0.270	1.931 1.529 2.348	2.858 6.516
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride	SiF ₄ SO ₂ SF ₆ SF ₄	0.395 0.728 0.270 0.353	1.931 1.529 2.348 1.957	2.858 6.516 4.776
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide	SiF ₄ SO ₂ SF ₆ SF ₄ SO ₃	0.395 0.728 0.270 0.353 0.535	1.931 1.529 2.348 1.957 1.691	2.858 6.516 4.776 3.575
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride	SiF ₄ SO ₂ SF ₆ SF ₄ SO ₃ SO ₂ F ₂	0.395 0.728 0.270 0.353 0.535 0.423	1.931 1.529 2.348 1.957 1.691 1.931	2.858 6.516 4.776 3.575 4.648
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide	SiF ₄ SO ₂ SF ₆ SF ₄ SO ₃	0.395 0.728 0.270 0.353 0.535	1.931 1.529 2.348 1.957 1.691	2.858 6.516 4.776 3.575
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane	SiF ₄ SO ₂ SF ₆ SF ₄ SO ₃ SO ₂ F ₂ CCL ₄	0.395 0.728 0.270 0.353 0.535 0.423 0.344	1.931 1.529 2.348 1.957 1.691 1.931 2.345	2.858 6.516 4.776 3.575 4.648 6.858
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE)	SiF_4 SO_2 SF_6 SF_4 SO_3 SO_2F_2 CCL_4 C_2F_4	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905	2.858 6.516 4.776 3.575 4.648 6.858 4.526
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE) Tetrafluorohydrazine	SiF_4 SO_2 SF_6 SF_4 SO_3 SO_2F_2 CCL_4 C_2F_4 N_2F_4	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.526 4.624
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfuryl Fluoride Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE)	SiF_4 SO_2 SF_6 SF_4 SO_3 SO_2F_2 CCL_4 C_2F_4	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905	2.858 6.516 4.776 3.575 4.648 6.858 4.526
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Triafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE) Tetrafluorohydrazine	SiF_4 SO_2 SF_6 SF_4 SO_3 SO_2F_2 CCL_4 C_2F_4 N_2F_4	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.526 4.624
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfuryl Fluoride Tetrafluoride Tetrafluoromethane Tetrafluoroethylene (TFE) Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane	$\begin{array}{c} {\rm SiF_4} \\ {\rm SO_2} \\ {\rm SF_6} \\ {\rm SF_4} \\ {\rm SO_3} \\ {\rm SO_2F_2} \\ \hline \\ {\rm CCL_4} \\ {\rm C_2F_4} \\ {\rm N_2F_4} \\ {\rm CCL_3F} \\ {\rm SiHCL_3} \\ \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorothylene (TFE) Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB)	$\begin{array}{c} {\rm SiF_4} \\ {\rm SO_2} \\ {\rm SF_6} \\ {\rm SF_4} \\ {\rm SO_3} \\ {\rm SO_2F_2} \\ \hline \\ {\rm CCL_4} \\ {\rm C_2F_4} \\ {\rm N_2F_4} \\ {\rm CCL_3F} \\ {\rm SiHCL_3} \\ {\rm B(OCH_3)_3} \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113	$SiF_{4} \\ SO_{2} \\ SF_{6} \\ SF_{4} \\ SO_{3} \\ SO_{2}F_{2} \\ \hline CCL_{4} \\ C_{2}F_{4} \\ N_{2}F_{4} \\ CCL_{3}F \\ SiHCL_{3} \\ B(OCH_{3})_{3} \\ C_{2}CL_{3}F_{3} \\ \hline \end{array}$	0.395 0.728 0.270 0.353 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorothylene (TFE) Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB)	$\begin{array}{c} {\rm SiF_4} \\ {\rm SO_2} \\ {\rm SF_6} \\ {\rm SF_4} \\ {\rm SO_3} \\ {\rm SO_2F_2} \\ \hline \\ {\rm CCL_4} \\ {\rm C_2F_4} \\ {\rm N_2F_4} \\ {\rm CCL_3F} \\ {\rm SiHCL_3} \\ {\rm B(OCH_3)_3} \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine	SiF_{4}^{-} SO_{2}^{-} SF_{6}^{-} SF_{4}^{-} $SO_{2}F_{2}^{-}$ CCL_{4}^{-} $C_{2}F_{4}^{-}$ $CCL_{3}F_{4}^{-}$ $CCL_{3}F_{4}^{-}$ $B(OCH_{3})_{3}^{-}$ $C_{2}CL_{3}F_{3}^{-}$ $(CH_{3})_{3}N$	0.395 0.728 0.270 0.353 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Triafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride	$SiF_{4} \\ SO_{2} \\ SF_{6} \\ SF_{6} \\ SF_{4} \\ SO_{3} \\ SO_{2}F_{2} \\ CCL_{4} \\ C_{2}F_{4} \\ C_{2}F_{4} \\ CCL_{3}F \\ SiHCL_{3} \\ B(OCH_{3})_{3} \\ C_{2}CL_{3}F_{3} \\ (CH_{3})_{3}N \\ WF_{6} \\ WF_{6} \\ \end{bmatrix}$	0.395 0.728 0.270 0.353 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride Uranimum Hexafluoride	$SiF_{4} \\ SO_{2} \\ SF_{6} \\ SF_{4} \\ SO_{3} \\ SO_{2}F_{2} \\ CCL_{4} \\ C_{2}F_{4} \\ CCL_{3}F \\ SiHCL_{3} \\ B(OCH_{3})_{3} \\ C_{2}CL_{3}F_{3} \\ (CH_{3})_{3}N \\ WF_{6} \\ UF_{6} \\ \end{bmatrix}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227 0.220	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264 3.548	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28 15.70
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE) Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride Uranimum Hexafluoride Vinyl Bromide	$\begin{array}{c} {\rm SiF_4}\\ {\rm SO_2}\\ {\rm SF_6}\\ {\rm SF_6}\\ {\rm SF_4}\\ {\rm SO_3}\\ {\rm SO_2F_2}\\ \hline \\ {\rm CCL_4}\\ {\rm C_2F_4}\\ {\rm C_2F_4}\\ {\rm CCL_3F}\\ {\rm SiHCL_3}\\ {\rm B(OCH_3)_3}\\ {\rm C_2CL_3F_3}\\ {\rm (CH_3)_3N}\\ {\rm WF_6}\\ \hline \\ {\rm UF_6}\\ \hline \\ {\rm C_2H_3Br}\\ \hline \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227 0.220 0.524	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264 3.548 1.985	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28 15.70 4.772
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride Uranimum Hexafluoride	$\begin{array}{c} {\rm SiF_4}\\ {\rm SO_2}\\ {\rm SF_6}\\ {\rm SF_6}\\ {\rm SF_4}\\ {\rm SO_3}\\ {\rm SO_2F_2}\\ \hline \\ {\rm CCL_4}\\ {\rm C_2F_4}\\ {\rm N_2F_4}\\ {\rm CCL_3F}\\ {\rm SiHCL_3}\\ {\rm B(OCH_3)_3}\\ {\rm C_2CL_3F_3}\\ {\rm (CH_3)_3N}\\ {\rm WF_6}\\ \hline \\ {\rm UF_6}\\ \hline \\ {\rm UF_6}\\ {\rm C_2H_3Br}\\ {\rm C_2H_3CL}\\ \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227 0.220	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264 3.548	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28 15.70
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluoroethylene (TFE) Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride Uranimum Hexafluoride Vinyl Bromide	$\begin{array}{c} {\rm SiF_4}\\ {\rm SO_2}\\ {\rm SF_6}\\ {\rm SF_6}\\ {\rm SF_4}\\ {\rm SO_3}\\ {\rm SO_2F_2}\\ \hline \\ {\rm CCL_4}\\ {\rm C_2F_4}\\ {\rm C_2F_4}\\ {\rm CCL_3F}\\ {\rm SiHCL_3}\\ {\rm B(OCH_3)_3}\\ {\rm C_2CL_3F_3}\\ {\rm (CH_3)_3N}\\ {\rm WF_6}\\ \hline \\ {\rm UF_6}\\ \hline \\ {\rm C_2H_3Br}\\ \hline \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227 0.220 0.524	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264 3.548 1.985	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28 15.70 4.772
Silicon Tetrafluoride Sulfur Dioxide Sulfur Hexafluoride Sulfur Tetrafluoride Sulfur Trioxide Sulfuryl Fluoride Tetrachloromethane Tetrafluorohydrazine Trichlorofluoromethane f-11 Trichlorofluoromethane f-11 Trichlorosilane Trimethyloxyborane (TMB) 1,1,2-Trichloro-1,1,2-Triflouroet f-113 Trimethylamine Tungsten Hexafluoride Uranimum Hexafluoride Uranimum Hexafluoride Vinyl Bromide Vinyl Chloride	$\begin{array}{c} {\rm SiF_4}\\ {\rm SO_2}\\ {\rm SF_6}\\ {\rm SF_6}\\ {\rm SF_4}\\ {\rm SO_3}\\ {\rm SO_2F_2}\\ \hline \\ {\rm CCL_4}\\ {\rm C_2F_4}\\ {\rm N_2F_4}\\ {\rm CCL_3F}\\ {\rm SiHCL_3}\\ {\rm B(OCH_3)_3}\\ {\rm C_2CL_3F_3}\\ {\rm (CH_3)_3N}\\ {\rm WF_6}\\ \hline \\ {\rm UF_6}\\ \hline \\ {\rm UF_6}\\ {\rm C_2H_3Br}\\ {\rm C_2H_3CL}\\ \end{array}$	0.395 0.728 0.270 0.353 0.535 0.423 0.344 0.361 0.367 0.374 0.329 0.300 0.231 0.316 0.227 0.220 0.524 0.542	1.931 1.529 2.348 1.957 1.691 1.931 2.345 1.905 1.926 2.244 2.201 1.929 2.520 1.467 3.264 3.548 1.985 1.492	2.858 6.516 4.776 3.575 4.648 6.858 4.526 4.624 6.281 6.038 4.638 7.920 2.639 13.28 15.70 4.772 2.788

Brooks[®] Model 5850E

Mixture Factor =
$$\frac{100}{\frac{20}{1.386} + \frac{80}{0.876}} = 0.945$$

Nitrogen equivalent flow = 20/.945 = 21.16 slpm Nitrogen

It is generally accepted that the mass flow rate derived from this equation is only accurate to \pm 5%. The sensor conversion factors given in Table 4-4 are calculated based on a gas temperature of 21°C and a pressure of one atmosphere. The specific heat of most gases is not strongly pressure, and/ or temperature, dependent. However, gas conditions that vary widely from these reference conditions may cause an additional error due to the change in specific heat caused by pressure and/or temperature.

4-6 Orifice Sizing

The Orifice Sizing Nomograph, Figure 4-4, is used to calculate the control valve's orifice size when changing any or all of the following factors from the original factory calibration:

gas operating pressure (inlet and outlet) flow range

The flow controller's orifice is factory-sized to a preselected gas, operating pressure and flow range. Note that the orifice is marked with its size in thousandths of an inch. When changing the aforementioned factors, calculate the new orifice size by following the procedure and example outlined in the following paragraphs.

Example: Determine the orifice size for the following conditions:

Gas:HydrogenFlow Rate:2,000 sccmOutlet Pressure:30 psigInlet Pressure:50 psig

1. Determine Nitrogen equivalent flow rate (refer to Table 4-3).

$$Q_{\text{NITROGEN}} = Q_{GA}$$

$$\frac{P_{GAS}}{P_{NITROGEN}}$$

SG_{GAS} SG_{NITROGEN}

OR

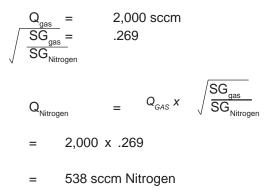
 $Q_{NITROGEN}$ = Nitrogen equivalent flow rate (sccm)

4-17

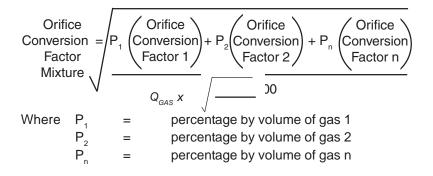
Q_{GAS}	=	Desired flow rate of the gas (sccm)
P _{NITROGEN}	=	Density of Nitrogen at 70°F
P _{GAS}	=	Density of the gas (taken at customer temperature)
SG_{GAS}	=	Specific gravity of the gas (taken at customer temperature)

Refer to Table 4-4 for specific gravities.

Example:



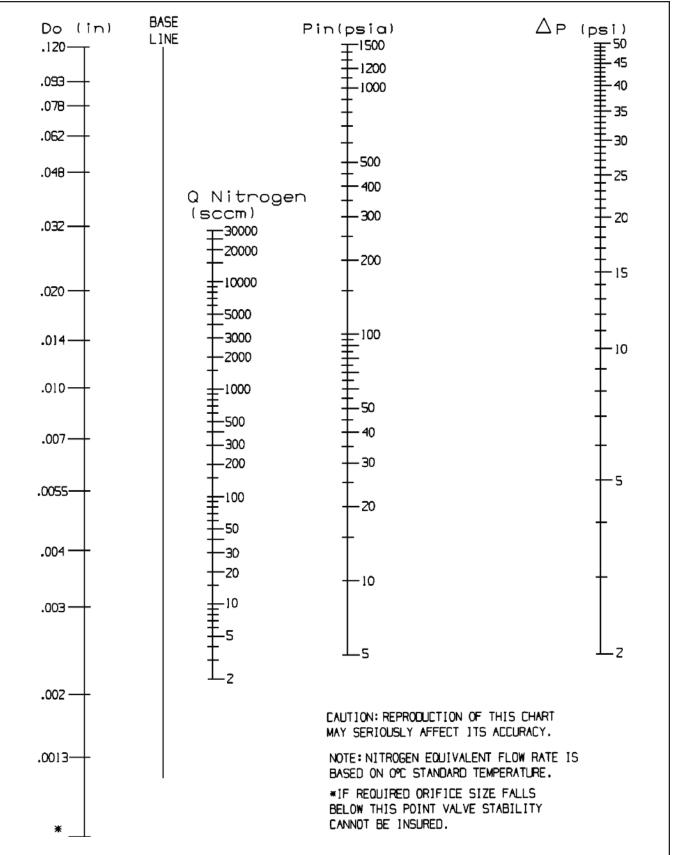
In order to calculate the orifice conversion factor when using a gas mixture, the following formula must be used:



Example: Find the Nitrogen equivalent for 20 slpm of a 20% Helium and 80% Chlorine gas mixture.

Orifice Conversion Factor Mixture	=	20(.378)	+ 100	80(1.598)
Q _{Nitrogen}	=	Q _{gas} (ori	fice co	onversion factor)
	=	20 x 1	.439	
	=	28.78 s	lpm N	itrogen





Section 4 Maitenance & Troubleshooting

Brooks[®] Model 5850E

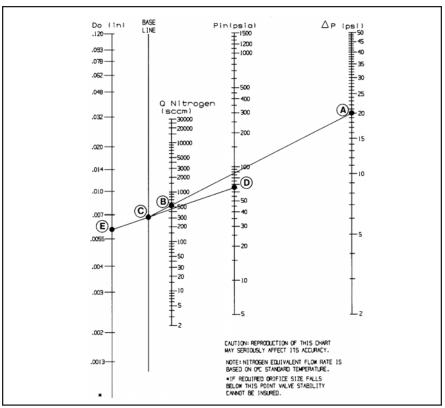


Figure 4-4 Example Nomograph

2. If inlet and outlet pressures are given in gauge pressure (psig) add 14.7 to convert to absolute pressure (psia).

Outlet Pressure — 30 psig + 14.7 = 44.7 psia Inlet Pressure — 50 psig + 14.7 = 64.7 psia

3. Determine Critical Pressure Drop Critical pressure drop occurs when the outlet pressure (psia) is less than half the inlet pressure (psia) or

Poutlet <
$$\frac{P \text{ inlet}}{2}$$

If these conditions exist, the pressure drop (Dp) should be calculated as follows:

$$Dp = \frac{P_{in}}{2}$$

$$Dp = Pressure drop (psi)$$

$$P_{in} = Inlet pressure (psia)$$

If these conditions do not exist, pressure drop equals the inlet pressure minus the outlet pressure.

(psia)

ls 44.7 psia $< \frac{64.7 \text{ psia}}{2}$

<u>a</u>? No.

Then Dp = 64.7 - 44.7 = 20psi

- 4. Using the nomograph, locate the pressure drop (psi) on the vertical line marked "Dp" (Point A).
- Locate the Nitrogen equivalent flow rate (sccm Nitrogen) on the vertical line marked "Q_{Nitrogen}" (Point B).
- 6. Draw a line connecting Dp and $Q_{Nitrogen}$ and extend it to the baseline. Mark this point (Point C).
- 7. Locate inlet pressure (psia) on the vertical line marked "P_{in}" (Point D).
- Draw a line connecting P_{in} (Point D) and baseline (Point C) and then extend this line to the vertical line marked D_o (orifice diameter, inches) (Point E).
- 9. This point on the line is the minimum orifice size for the given conditions. If this point is between two orifice sizes, select the next largest size orifice to ensure adequate flow. If the orifice selected falls below .0013, choose .0013 size orifice.

For the example in Figure 4-5, the .007 size orifice would be selected.

4-7 Restrictor Sizing

The restrictor assembly is a ranging device for the sensor portion of the controller. It creates a pressure drop which is linear with flow rate. This diverts a sample quantity of the process gas flow through the sensor. Each restrictor maintains the ratio of sensor flow to restrictor flow, however the total flow through each restrictor is different. Different restrictors (micron porosity and active area) have different pressure drops and produce controllers with different full scale flow rates. For a discussion of the interaction of the various parts of the controller, you are urged to review Section 3-1 (Theory of Operation).

If the restrictor assembly has been contaminated with foreign matter, the pressure drop vs. flow characteristics will be altered and it must be cleaned or replaced. It may also be necessary to replace the restrictor assembly when the mass flow controller is to be calibrated to a new flow rate.

Restrictor assembly replacement should be performed only by trained personnel. The tools required for the removal/replacement procedure are as follows:

Appropriate size wrench for the removal of the inlet process connection Restrictor removal tool (contained in service tool kit P/N S-778-D-017-AAA)

Restrictor O-ring, refer to the spare parts Section 5, for the correct part number.

Restrictors

The Model 5850E Series Mass Flow Controllers use three types of restrictor assemblies depending on full scale flowrate and expected service conditions.

- 1. Porous sintered metal for air equivalent flow rates up to and including 9.5 slpm. The porosity ranges from 1-40 microns. This type of assembly is least expensive and should be used when the gas stream will not contain any particulate matter.
- 2. Sintered wire mesh for air equivalent flow rates above 3.5 slpm. These restrictor assemblies are made from a cylinder of sintered wire mesh and are easily cleaned if they become contaminated in service.
- 3. Anti-Clog Laminar Flow Element (ACLFE). This type of restrictor assembly is used for air equivalent flow rates less than 3.4 slpm. The ACLFE is much more tolerant to particulate contamination than the sintered metal assembly. This is especially important when handling semiconductor gases that tend to precipitate particles. The ACLFE will also improve accuracy when operating at very low pressures.

Sizing

All Model 5850E Series Restrictor Assemblies are factory adjusted to provide a 115 mm water column pressure drop for a specific flow rate. This corresponds to the desired full scale flow rate. A list of restrictor assemblies used in the Model 5850E Series Mass Flow Controllers is shown in Table 4-5.

Example:

The desired gas is Silane (SiH4). The desired full scale flow rate is 200 sccm. Sensor conversion factor is 0.625 from Table 4-4. Nitrogen equivalent flow = 200/0.625 = 320 sccm Nitrogen.

In the example above a size P restrictor would be selected. Both the sintered metal and ACLFE are available for this size. Either type will work however, since Silane is known to precipitate silicon dioxide particles when contaminated an anti-clog laminar flow element should be selected for this application.

Note: If the calculated flow rate is such that two different size restrictors could be used, always select the larger size.

If a mixture of two or more gases are being used the restrictor selection must be based on the Nitrogen equivalent flow rate of the mixture.

Example:

The desired gas is 20% Helium (He) and 80% Chlorine (Cl) by volume. The desired full scale flow rate of the mixture is 20 slpm. Sensor conversion factor for the mixture is: Mixture Factor = $\frac{100}{\frac{20}{1.386} + \frac{80}{0.876}} = 0.945$

Nitrogen equivalent flow = 20/.945 = 21.16 slpm Nitrogen. In this example a Size 4 Wire Mesh Assembly would be selected.

	Range SCCM Air Equivalent Flow			Part Number	
Size	Low High		Sintered	ACLFE	Wire Mesh
D	8.022	11.36	S 110 Z 296*	S 110 Z 275*	
E	11.23	15.90	S 110 Z 297	S 110 Z 276	
F	15.72	22.26	S 110 Z 298	S 110 Z 277	
G	22.01	31.17	S 110 Z 299	S 110 Z 278	
Н	30.82	43.64	S 110 Z 300	S 110 Z 279	
J	43.14	61.09	S 110 Z 301	S 110 Z 280	
К	60.40	85.53	S 110 Z 302	S 110 Z 281	
L	84.56	119.7	S 110 Z 303	S 110 Z 282	
М	118.4	167.6	S 110 Z 304	S 110 Z 283	
Ν	165.7	234.7	S 110 Z 305	S 110 Z 284	
Р	232.0	328.6	S 110 Z 306	S 110 Z 285	
Q	324.8	460.0	S 110 Z 307	S 110 Z 286	
R	454.8	644.0	S 110 Z 308	S 110 Z 287	
S	636.7	901.6	S 110 Z 309	S 110 Z 288	
Т	891.4	1262.	S 110 Z 310	S 110 Z 289	
U	1248.	1767.	S 110 Z 311	S 110 Z 290	99999999 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 1997 - 19
V	1747.	2474.	S 110 Z 312	S 110 Z 291	
W	2446.	3464.	S 110 Z 313	S 110 Z 292	
Х	3424.	4849.			S 110 Z 319*
Y	4794.	6789.			S 110 Z 321
1	6711.	9504.			S 110 Z 317
2	9396.	13310.			S 110 Z 228
3	13150.	18630.			S 110 Z 226
4	18420.	30000.			S 110 Z 224

Table 4-5 Model 5850E Standard Restrictors

*Materials: BMT = 316 Stainless Steel (ACLFE only)

BMA = Sintered 316 Stainless Steel (wire mesh and sintered)

Note: For flow rates less than 8 sccm use the low flow plug, P/N 618-K-019-BMT in place of a restrictor assembly and install a low flow filler ring P/N 724 Z 429 BMT in the valve cavity after the orifice is installed.

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Dansk

Brooks Instrument 407 West Vine St. Hatfield, PA 19440 U.S.A. Emne : Tillæg til instruktions manual. Reference : CE mærkning af Masse Flow udstyr Dato : Januar-1996.

Brooks Instrument har gennemført CE mærkning af elektronisk udstyr med succes, i henhold til regulativet om elektrisk støj (EMC direktivet 89/336/EEC).

Der skal dog gøres opmærksom på benyttelsen af signalkabler i forbindelse med CE mærkede udstyr.

Kvaliteten af signal kabler og stik:

Brooks lever kabler af høj kvalitet, der imødekommer specifikationerne til CE mærkning.

Hvis der anvendes andre kabel typer skal der benyttes et skærmet kabel med hel skærm med 100% dækning.

Forbindelses stikket type "D" eller "cirkulære", skal være skærmet med metalhus og eventuelle PG-forskruninger skal enten være af metal eller metal skærmet.

Skærmen skal forbindes, i begge ender, til stikkets metalhus eller PG-forskruningen og have forbindelse over 360 grader. Skærmen bør være forbundet til jord.

"Card Edge" stik er standard ikke af metal, der skal derfor ligeledes benyttes et skærmet kabel med hel skærm med 100% dækning.

Skærmen bør være forbundet til jord.

Forbindelse af stikket; venligst referer til vedlagte instruktions manual.

Med venlig hilsen,

Deutsch

Brooks Instrum 407 West Vine Hatfield, PA 1	e St.	
U.S.A.	7440	
Subject	:	Nachtrag zur Bedienungsanleitung.
Referenz	:	CE Zertifizierung für Massedurchflußgeräte
Datum	:	Januar-1996.

Nach erfolgreichen Tests enstprechend den Vorschiften der Elektromagnetischen Verträglichkeit (EMC Richtlinie 89/336/ EEC) erhalten die Brooks-Geräte (elektrische/elektronische Komponenten) das CE-Zeichen.

Bei der Auswahl der Verbindungskabel für CE-zertifizierte Geräte sind spezielle Anforderungen zu beachten.

Qualität der Verbindungskabel, Anschlußstecker und der Kabeldurchführungen

Die hochwertigen Qualitätskabel von Brooks entsprechen der Spezifikation der CE-Zertifizierung.

Bei Verwendung eigener Verbindungskabel sollten Sie darauf achten, daß eine

100 %igenSchirmababdeckung des Kabels gewährleistet ist.

"D" oder "Rund" - Verbindungsstecker sollten eine Abschirmung aus Metall besitzen.

Wenn möglich, sollten Kabeldurchführungen mit Anschlußmöglichkeiten für die Kabelabschrimung verwendet werden.

Die Abschirmung des Kabels ist auf beiden Seiten des Steckers oder der Kabeldurchführungen über den vollen Umfang von 360° anzuschließen.

Die Abschirmung ist mit dem Erdpotential zu verbinden.

Platinen-Steckverbindunger sind standardmäßige keine metallgeschirmten Verbindungen. Um die Anforderungen der CE-Zertifizierung zu erfüllen, sind Kabel mit einer 100 %igen Schirmababdeckung zu verwenden.

Die Abschirmung ist mit dem Erdpotential zu verbinden.

Die Belegung der Anschlußpins können Sie dem beigelegten Bedienungshandbuch entnehmen.

English

Brooks Instrum	ent	
407 West Vine	St.	
Hatfield, PA 19	440	
U.S.A.		
Subject	:	Addendum to the Instruction Manual.
Reference	:	CE certification of Mass Flow Equipment
Date	:	January-1996.

The Brooks (electric/electronic) equipment bearing the CE mark has been successfully tested to the regulations of the Electro Magnetic Compatibility (EMC directive 89/336/EEC).

Special attention however is required when selecting the signal cable to be used with CE marked equipment.

Quality of the signal cable, cable glands and connectors:

Brooks supplies high quality cable(s) which meets the specifications for CE certification.

If you provide your own signal cable you should use a cable which is overall completely screened with a 100% shield.

"D" or "Circular" type connectors used should be shielded with a metal shield. If applicable, metal cable glands must be used providing cable screen clamping.

The cable screen should be connected to the metal shell or gland and shielded at both ends over 360 Degrees.

The shield should be terminated to a earth ground.

Card Edge Connectors are standard non-metallic. The cables used must be screened with 100% shield to comply with CE certification.

The shield should be terminated to a earth ground.

For pin configuration : Please refer to the enclosed Instruction Manual.

Español

Brooks Instrum 407 West Vine Hatfield, PA 1	e St.	
,	9440	
U.S.A.		
Asunto	:	Addendum al Manual de Instrucciones.
Referencia	:	Certificación CE de los Equipos de Caudal Másico
Fecha	:	Enero-1996.

Los equipos de Brooks (eléctricos/electrónicos) en relación con la marca CE han pasado satisfactoriamente las pruebas referentes a las regulaciones de Compatibilidad Electro magnética (EMC directiva 89/336/EEC).

Sin embargo se requiere una atención especial en el momento de seleccionar el cable de señal cuando se va a utilizar un equipo con marca CE

Calidad del cable de señal, prensaestopas y conectores:

Brooks suministra cable(s) de alta calidad, que cumple las especificaciones de la certificación CE .

Si usted adquiere su propio cable de señal, debería usar un cable que esté completamente protegido en su conjunto con un apantallamiento del 100%.

Cuando utilice conectores del tipo "D" ó "Circular" deberían estar protegidos con una pantalla metálica. Cuando sea posible, se deberán utilizar prensaestopas metálicos provistos de abrazadera para la pantalla del cable.

La pantalla del cable deberá ser conectada al casquillo metálico ó prensa y protegida en ambos extremos completamente en los 360 Grados.

La pantalla deberá conectarse a tierra.

Los conectores estandar de tipo tarjeta (Card Edge) no son metálicos, los cables utilizados deberán ser protegidos con un apantallamiento del 100% para cumplir con la certificación CE.

La pantalla deberá conectarse a tierra.

A-2 Para ver la configuración de los pines: Por favor, consultar Manual de Instrucciones adjunto.

Français

Brooks Instrum 407 West Vine Hatfield, PA 1	St.	
U.S.A.		
Sujet	:	Annexe au Manuel d'Instructions.
Référence	:	Certification CE des Débitmètres Massiques à Effet Thermique.
Date	:	Janvier 1996.
N ·		

Messieurs,

Les équipements Brooks (électriques/électroniques) portant le label CE ont été testés avec succès selon les règles de la Compatibilité Electromagnétique (directive CEM 89/336/EEC).

Cependant, la plus grande attention doit être apportée en ce qui concerne la sélection du câble utilisé pour véhiculer le signal d'un appareil portant le label CE.

Qualité du câble, des presse-étoupes et des connecteurs:

Brooks fournit des câbles de haute qualité répondant aux spécifications de la certification CE.

Si vous approvisionnez vous-même ce câble, vous devez utiliser un câble blindé à 100 %.

Les connecteurs « D » ou de type « circulaire » doivent être reliés à la terre.

Si des presse-étoupes sont nécessaires, ceux ci doivent être métalliques avec mise à la terre.

Le blindage doit être raccordé aux connecteurs métalliques ou aux presse-étoupes sur le pourtour complet du câble, et à chacune de ses extrémités.

Tous les blindages doivent être reliés à la terre.

Les connecteurs de type « card edge » sont non métalliques. Les câbles utilisés doivent être blindés à 100% pour satisfaire à la réglementation CE.

Tous les blindages doivent être reliés à la terre.

Se référer au manuel d'instruction pour le raccordement des contacts.

Greek

Brooks Instrument 107 West Vine St. Hatfield, PA 19440 U.S.A. Ͽέμα :Προσθήκη στο Εγχειρίδιο Οδηγιών. Εχετικά :Πιστοποίηση CE των Οργάνων Μέτρησης Παροχής Μάζας. Ημερομηνία :Ιανουάριος - 1996

ζυρίες και Κύριοι,

Γα όργανα (ηλεκτρικά/ηλεκτρονικά) της Brooks τα οποία φέρουν το σήμα CE έχουν πιτυχώς ελεγχθεί σύμφωνα με τους κανονισμούς της Ηλεκτρο-Μαγνητικής λυμβατότητας (EMC ντιρεκτίβα 89/336/EEC).

)πωσδήποτε χρειάζεται ειδική προσοχή κατά τήν επιλογή του καλωδίου μεταφοράς ου σήματος το οποίο (καλώδιο) πρόκειται να χρησιμοποιηθεί με όργανα που φέρουν ο σήμα CE.

Ιοιότητα του καλωδίου σήματος των στυπιοθλιπτών και των συνδέσμων.

I Brooks κατά κανόνα προμηθεύει υψηλής ποιότητας καλώδια τα οποία πληρούν τις ροδιαγραφές για πιστοποίηση CE.

λάν η επιλογή του καλωδίου σήματος γίνει από σας πρέπει να χρησιμοποιήσετε αλώδιο το οποίο να φέρει εξωτερικά πλήρες πλέγμα και να παρέχει θωράκιση 00%.

h σύνδεσμοι τύπου "D" ή "Κυκλικοί" των καλωδίων, πρέπει να θωρακίζονται με εταλλική θωράκιση. Εάν είναι εφαρμόσιμο, πρέπει να χρησιμοποιούνται μεταλλικοί τυπιοθλίπτες καλωδίων που να διαθέτουν ακροδέκτη σύνδεσης του πλέγματος του αλωδίου.

ο πλέγμα του καλωδίου πρέπει να συνδέεται στο μεταλλικό περίβλημα ή στον τυπιοθλίπτη και να θωρακίζεται και στα δύο άκρα κατά 360 μοίρες. [θωράκιση πρέπει να καταλήγει σε κάποιο ακροδέκτη γείωσης.

ι σύνδεσμοι καρτών είναι μη-μεταλλικοί, τα καλώδια που χρησιμοποιούνται πρέπει
 ι φέρουν πλέγμα θωράκισης 100% για να υπακούουν στην πιστοποίηση CE.
 θωράκιση πρέπει να καταλήγει σε κάποιο ακροδέκτη γείωσης.

ια την διάταξη των ακροδεκτών: Παρακαλούμε αναφερθείτε στο εσώκλειστο γχειρίδιο Οδηγιών.

Italiano

Brooks Instrume 407 West Vine S Hatfield, PA 19	St.	
U.S.A.		
Oggetto	:	Addendum al manuale di istruzioni.
Riferimento	:	Certificazione CE dei misuratori termici di portata in massa
Data	:	Gennaio 1996.

Questa strumentazione (elettrica ed elettronica) prodotta da Brooks Instrument, soggetta a marcatura CE, ha superato con successo le prove richieste dalla direttiva per la Compatibilità Elettomagnetica (Direttiva EMC 89/336/EEC).

E' richiesta comunque una speciale attenzione nella scelta dei cavi di segnale da usarsi con la strumentazione soggetta a marchio CE.

Qualità dei cavi di segnale e dei relativi connettori:

Brooks fornisce cavi di elevata qualità che soddisfano le specifiche richieste dalla certificazione CE. Se l'utente intende usare propri cavi, questi devono possedere una schermatura del 100%.

I connettori sia di tipo "D" che circolari devono possedere un guscio metallico. Se esiste un passacavo esso deve essere metallico e fornito di fissaggio per lo schermo del cavo.

Lo schermo del cavo deve essere collegato al guscio metallico in modo da schermarlo a 360° e questo vale per entrambe le estemità.

Lo schermo deve essere collegato ad un terminale di terra.

I connettori "Card Edge" sono normalmente non metallici. Il cavo impiegato deve comunque avere una schermatura del 100% per soddisfare la certificazione CE.

Lo schermo deve essere collegato ad un terminale di terra.

Per il corretto cablaggio dei terminali occorre fare riferimento agli schemi del manuale di istruzioni dello strumento.

Nederlands

Brooks Instrument 407 West Vine St. Hatfield, PA 19440 U.S.A. Onderwerp : Addendum voor Instructie Handboek Referentie: CE certificering voor Mass Flow Meters & Controllers Datum : Januari 1996

Dames en heren,

Alle CE gemarkeerde elektrische en elektronische produkten van Brooks Instrument zijn met succes getest en voldoen aan de wetgeving voor Electro Magnetische Compatibiliteit (EMC wetgeving volgens 89/336/EEC).

Speciale aandacht is echter vereist wanneer de signaalkabel gekozen wordt voor gebruik met CE gemarkeerde produkten.

Kwaliteit van de signaalkabel en kabelaansluitingen:

- Brooks levert standaard kabels met een hoge kwaliteit, welke voldoen aan de specificaties voor CE certificering. Indien men voorziet in een eigen signaalkabel, moet er gebruik gemaakt worden van een kabel die volledig is afgeschermd met een bedekkingsgraad van 100%.
- "D" of "ronde" kabelconnectoren moeten afgeschermd zijn met een metalen connector kap. Indien kabelwartels worden toegepast, moeten metalen kabelwartels worden gebruikt die het mogelijk maken het kabelscherm in te klemmen Het kabelscherm moet aan beide zijden over 360° met de metalen connectorkap, of wartel verbonden worden. Het scherm moet worden verbonden met aarde.
- "Card-edge" connectors zijn standaard niet-metallisch. De gebruikte kabels moeten volledig afgeschermd zijn met een bedekkingsgraad van 100% om te voldoen aan de CE certificering.

Het scherm moet worden verbonden met aarde.

Voor pin-configuraties a.u.b. verwijzen wij naar het bijgesloten instruktie handboek.

Norsk

Brooks Instrume 407 West Vine S Hatfield, PA 194	st.	
U.S.A.		
Vedrørende	:	Vedlegg til håndbok
Referanse	:	CE sertifisering av utstyr for massestrømsmåling og regulering
Dato	:	Januar 1996

Til den det angår

Brooks Instrument elektrisk og elektronisk utstyr påført CE-merket har gjennomgått og bestått prøver som beskrevet i EMC forskrift om elektromagnetisk immunitet, direktiv 89/336/EEC.

For å opprettholde denne klassifisering er det av stor viktighet at riktig kabel velges for tilkobling av det måletekniske utstyret.

Utførelse av signalkabel og tilhørende plugger:

- Brooks Instrument tilbyr levert med utstyret egnet kabel som møter de krav som stilles til CE-sertifisering.
- Dersom kunden selv velger kabel, må kabel med fullstendig, 100% skjerming av lederene benyttes.

"D" type og runde plugger og forbindelser må være utført med kappe i metall og kabelnipler må være utført i metall for jordet innfesting av skjermen. Skjermen i kabelen må tilknyttes metallet i pluggen eller nippelen i begge ender over 360°, tilkoblet elektrisk jord.

• Kort-kantkontakter er normalt utført i kunststoff. De tilhørende flatkabler må være utført med fullstendig, 100% skjerming som kobles til elektrisk jord på riktig pinne i pluggen, for å møte CE sertifiseringskrav.

For tilkobling av medleverte plugger, vennligst se håndboken som hører til utstyret. Vennlig hilsen

Português

Brooks Instrum	ent	
407 West Vine	St.	
Hatfield, PA 19440		
U.S.A.		
Assunto	:	Adenda ao Manual de Instruções
Referência	:	Certificação CE do Equipamento de Fluxo de Massa
Data	:	Janeiro de 1996.

O equipamento (eléctrico/electrónico) Brooks com a marca CE foi testado com êxito nos termos do regulamento da Compatibilidade Electromagnética (directiva CEM 89/336/EEC).

Todavia, ao seleccionar-se o cabo de sinal a utilizar com equipamento contendo a marca CE, será necessário ter uma atenção especial.

Qualidade do cabo de sinal, buchas de cabo e conectores:

A Brooks fornece cabo(s) de qualidade superior que cumprem os requesitos da certificação CE.

Se fornecerem o vosso próprio cabo de sinal, devem utilizar um cabo que, na sua totalidade, seja isolado com uma blindagem de 100%.

Os conectores tipo "D" ou "Circulares" devem ser blindados com uma blindagem metálica. Se tal for necessário, deve utilizar-se buchas metálicas de cabo para o isolamento do aperto do cabo.

O isolamento do cabo deve ser ligado à blindagem ou bucha metálica em ambas as extremidades em 360°.

A blindagem deve terminar com a ligação à massa.

Os conectores "Card Edge" não são, em geral, metálicos e os cabos utilizados devem ter um isolamento com blindagem a 100% nos termos da Certificação CE..

A blindagem deve terminar com ligação à massa.

Relativamente à configuração da cavilha, queiram consultar o Manual de Instruções.

Suomi

Brooks Instrument	
407 West Vine St.	
Hatfield, PA 19440	
U.S.A.	
Asia	: Lisäys Käyttöohjeisiin
Viite	: Massamäärämittareiden CE sertifiointi
Päivämäärä	: Tammikuu 1996

Brooksin CE merkillä varustetut sähköiset laitteet ovat läpäissyt EMC testit (direktiivi 89/336/EEC).

Erityistä huomiota on kuitenkin kiinnitettävä signaalikaapelin valintaan.

Signaalikaapelin, kaapelin läpiviennin ja liittimen laatu

Brooks toimittaa korkealaatuisia kaapeleita, jotka täyttävät CE sertifikaatin vaatimukset. Hankkiessaan signaalikaapelin itse, olisi hankittava 100%:sti suojattu kaapeli.

"D" tai "Circular" tyyppisen liitimen tulisi olla varustettu metallisuojalla. Mikäli mahdollista, tulisi käyttää metallisia kaapeliliittimiä kiinnitettäessä suojaa.

Kaapelin suoja tulisi olla liitetty metallisuojaan tai liittimeen molemmissa päissä 360°:n matkalta.

Suojan tulisi olla maadoitettu.

"Card Edge Connector" it ovat standarditoimituksina ei-metallisia. Kaapeleiden täytyy olla 100%: sesti suojattuja jotta ne olisivat CE sertifikaatin mukaisia.

Suoja on oltava maadoitettu.

Nastojen liittäminen; katso liitteenä oleva manuaali.

Ystävällisin terveisin,

Svensk

Brooks Instrument 407 West Vine St. Hatfield, PA 19440 U.S.A. Subject : Addendum to the Instruction Manual Reference : CE certification of Mass Flow Equipment Date : January 1996

Brooks (elektriska / elektronik) utrustning, som är CE-märkt, har testats och godkänts enligt gällande regler för elektromagnetisk kompabilitet (EMC direktiv 89/336/EEC).

Speciell hänsyn måste emellertid tas vid val av signalkabel som ska användas tillsammans med CE-märkt utrustning.

Kvalitet på signalkabel och anslutningskontakter:

Brooks levererar som standard, kablar av hög kvalitet som motsvarar de krav som ställs för CE-godkännande.

Om man använder en annan signalkabel ska kabeln i sin helhet vara skärmad till 100%. "D" eller "runda" typer av anslutningskontakter ska vara skärmade. Kabelgenomföringar ska vara av metall alternativt med metalliserad skärmning.

Kabelns skärm ska, i bada ändar, vara ansluten till kontakternas metallkåpor eller genomföringar med 360 graders skärmning. Skärmen ska avslutas med en jordförbindelse.

Kortkontakter är som standard ej metalliserade, kablar som används måste vara 100% skarmade för att överensstämma med CEcertifieringen.

Skärmen ska avslutas med en jordförbindelse.

För elektrisk anslutning till kontaktstiften hänvisas till medföljande instruktionsmanual.

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Brooks[®] Model 5850E

LIMITED WARRANTY

Seller warrants that the Goods manufactured by Seller will be free from defects in materials or workmanship under normal use and service and that the Software will execute the programming instructions provided by Seller until the expiration of the earlier of twelve (12) months from the date of initial installation or eighteen (18) months from the date of shipment by Seller. Products purchased by Seller from a third party for resale to Buyer ("Resale Products") shall carry only the warranty extended by the original manufacturer.

All replacements or repairs necessitated by inadequate preventive maintenance, or by normal wear and usage, or by fault of Buyer, or by unsuitable power sources or by attack or deterioration under unsuitable environmental conditions, or by abuse, accident, alteration, misuse, improper installation, modification, repair, storage or handling, or any other cause not the fault of Seller are not covered by this limited warranty, and shall be at Buyer's expense.

Goods repaired and parts replaced during the warranty period shall be in warranty for the remainder of the original warranty period or ninety (90) days, whichever is longer. This limited warranty is the only warranty made by Seller and can be amended only in a writing signed by an authorized representative of Seller.

BROOKS SERVICE AND SUPPORT

Brooks is committed to assuring all of our customers receive the ideal flow solution for their application, along with outstanding service and support to back it up. We operate first class repair facilities located around the world to provide rapid response and support. Each location utilizes primary standard calibration equipment to ensure accuracy and reliability for repairs and recalibration and is certified by our local Weights and Measures Authorities and traceable to the relevant International Standards.

Visit www.BrooksInstrument.com to locate the service location nearest to you.

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Brooks Instrument can provide start-up service prior to operation when required.

For some process applications, where ISO-9001 Quality Certification is important, it is mandatory to verify and/or (re)calibrate the products periodically. In many cases this service can be provided under in-situ conditions, and the results will be traceable to the relevant international quality standards.

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In case you need technical assistance:

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Europe	2 +31 (0) 318 549 290
Asia	2 +81 (0) 3 5633 7100

Due to Brooks Instrument's commitment to continuous improvement of our products, all specifications are subject to change without notice.

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VCR	Cajon Company
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Brooks Instrument

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